

# NATIONAL AERONAUTICS AND SPACE ADMINISTRATION

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PRESSURE AND HEAT TRANSFER TESTS OF THE 0.040-SCALE

SPACE SHUTTLE ORBITER BASE HEATING MODEL (65-0) IN

THE JOHNSON SPACE CENTER SPACE ENVIRONMENT SIMULATION

LABORATORY THERMAL VACUUM CHAMBER A (CH79)

SPACE SHUTTLE

AEROTHERMODYNAMIC DATA REPORT

JOHNSON SPACE CENTER HOUSTON, TEXAS



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by

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NASA Series Number OH79

Model Number:

65-0

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#### ABSTRACT

Environment Simulation Laboratory (SESL) Thermal Vacuum Chamber A to determine space shuttle orbiter SSME plume-induced base pressure and heat transfer environments during simulated second-stage ascent trajectories. Specific objectives were (1) to provide verification of estimated environments used to design the SSME engine-mounted heat shield, (2) to provide environments for design of the SSME engine-mounted heat shield/orbiter-base heat shield interface seal, (3) to evaluate a central base heat shield flow protective device, (4) to provide SSME nozzle gimbaling limitation criteria for the ascent trajectories, (5) to provide detailed heating environments on the SSME nozzles, and (6) to evaluate heating penetration on the orbiter-base heat shield tile gap fillers.

Second-stage flight was simulated by firing the space shuttle main engines (SSME's) into the vacuum environment. The SSME's operated at one-half of full-scale chamber pressure. The O/F ratio and exhaust temperature were duplicated. To match the scaled SSME plume flow field,

# ABSTRACT (Concluded)

simulated altitude pressures were reduced one half. The model was tested at simulated altitudes of 120, 150, 180 and 240 thousand feet.

All objectives of Test OH79 were fulfilled. Twenty-nine chamber entries consisting of 105 model firings were obtained to support all six objectives. Specifically, fifteen entries (58 firings) supported the first two objectives, three entries (9 firings) supported the third objective, two entries (7 firings) supported the fourth objective, six entries (21 firings) supported the fifth objective, and three entries (10 firings) supported the sixth objective.

Tabulated pressure and heat transfer data are not presented with this report; they may be obtained as shown in Appendix A.

The model configuration, instrumentation, test procedures, and data reduction are described in this report.

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#### INTRODUCTION

Between first-stage ascent and orbit, the space shuttle vehicle, in its second stage, passes through an almost vacuum region where the orbiter base environment is dominated by the plume flow field generated by the space shuttle main engines. Because the orbiter is not a conventional rocket launch vehicle, its base region can be complicated by SSME nozzle gimbaling and local altitude conditions beyond existing analytical prediction methods. To assist the design of thermal protection for the orbiter base, the plume-induced pressures and heat transfer rates must be determined experimentally.

This investigation, Test OH79, was undertaken to measure base pressure and heat transfer rates on a scaled model of the space shuttle orbiter base region with firing rocket engines, SSME, duplicating the plume flow field to simulate recirculation and impingement in a near-vacuum environment. One hundred five SSME firings were obtained at four simulated altitudes (120, 150, 180 and 240 thousand feet) with SSME nozzle gimbal angle varying to simulate numerous second-stage shuttle flight trajectory conditions. Results of the investigation are presented in this report.

# NOMENCLATURE

PLOT SYMBOL	MNEMONIC	DEFINITION
	Chamber Paramet	ters_
h	ALTITUDE	simulated altitude, ft.
	Model Parameter	rs
	SSME 1	pitch and yaw gimbal angles, degrees
	SSME 2	pitch and yaw gimbal angles, degrees
	SSME 3	pitch and yaw gimbal angles, degrees
	Data Parameters	orbitat ossa, t a pluma-induced pressures
At ·	NOZZLE THROAT AREA	total SSME nozzle throat area, in.2
С		specific heat of the thin-film gauge substrate, BTU/lbm-OF
C*	CHARACTERISTIC VELOCITY	actual SSME characteristic throat velocity, ft/sec
C*th	THEORETICAL CHARACTERISTIC VELOCITY	theoretical SSME characteristic throat velocity, ft/sec
CHI		high calibration signal on Vidar tape, counts
CLO		low calibration signal on Vidar tape, counts
FS		millivolt equivalent to the high calibration signal on Vidar tape, millivolts
g		gravitational constant (32.174 $\frac{1bm}{1bf} \frac{ft}{sec^2}$ )
i		iteration variable
j		lower limit of averaging index interval
k		thermal conductivity of the thin-film gauge substrate, BTU/ft-sec-OF

# NOMENCIATURE (Continued)

PLOT SYMBOL	MNEMONIC	DEFINITION
	THI PONTE	a Cartesauri (Alba)
K		thin-film gauge substrate properties, BTU/ft2-sec1/2-oF
Kc		thin-film gauge calibration sensitivity at 70°F, Ohms/°F
KŢ		thin-film gauge sensitivity at $T_a$ , $Ohms/OF$
K70		thin-film gauge sensitivity at 70°F, Ohms/°F
1		upper limit of averaging index interval
mV		signal value in millivolts
mVc		millivolt level corrected for RC circuit discharge
n		number of time intervals from o to t
N		upper limit of n
OFF		pressure transducer offset, psi
P	BPOOXX	low range absolute pressure, Mpsia
ΔΡ		differential pressure due to model firing, Mpsi
$P_{A}$		chamber A internal pressure, TORR
PCOR		pressure correction, Mpsia
Pc	PC0005	SSME chamber pressure, psia
P <sub>H2</sub>	HV0002	steady state hydrogen venturi pressure, psia
P02	000001	steady state oxygen venturi pressure, psia
Po	0V0001 HV0002 0I0003 HI0004 PC0005	high range absolute pressure, psia

# NOMENCLATURE (Continued)

PLOT	MNEMONIC	DEFINITION	
ΔΡο		differential pressure due to model psi	firing,
Pref		transducer reference pressure, psi	
đ		instantaneous heat transfer rate, E	STU/ft2-sec
q <sub>e</sub>		constant heat transfer rate, BTU/ft	2-sec
q <sub>ss</sub>	HTXXXX	normalized heat transfer rate, BTU/	ft <sup>2</sup> -sec
r	MIXTURE RATIO	oxidizer/fuel ratio	
	141110		
RAW		signal value in digital counts	
Rc		thin-film gauge calibration resists 70°F, Ohms	ance at
$R_{\mathbf{G}}$		thin-film gauge resistance at Ta, (	hms
$R_{ m L}$		thin-film gauge circuit line resist	ance, Ohms
Rp		ratio of nominal to average SSME ch pressure	amber
S		pressure transducer bench calibrati sensitivity, mV/psi	.on
Sg		thin-film gauge conversion to <sup>O</sup> F, m	v/of
t		time, seconds	
Δt		time increment, seconds	
ΔΤ		differential temperature due to mod	el firing,
Ta		model steady state temperature prioring, ${}^{\circ}F$	or to
TCOR		reference temperature equivalent to	Ta, OF

# NCMENCLATURE (Concluded)

PLOT SYMBOL	MNEMONIC	DEFINITION
To		reference time, seconds
$V_{ps}$		thin-film gauge circuit power supply voltage, Volts
W <sub>H2</sub>	HYDROGEN WEIGHT FLOW	hydrogen weight flow rate, lb/sec
w <sub>02</sub>	OXYGEN WEIGHT FLOW	oxygen weight flow rate, lb/sec
ŴŢ	TOTAL NOZZLE WEIGHT FLOW	total nozzle weight flow rate, lb/sec
ZERO		millivolt equivalent to the low calibration signal on Vidar tape, millivolts
α		reciprocal of the thin-film gauge signal conducting gain
ης	COMBUSTION EFFICIENCY	SSME nozzle combustion efficiency
$\pi$		constant
ρ		density of the thin-film gauge substrate, lbm/ft3
τ bhayan re		RC circuit time constant, seconds

#### CONFIGURATIONS INVESTIGATED

#### General

Model 65-0 is an impulse type, hot firing 0.040-scale model of the aft portion of the orbiter vehicle 102 configuration. The propulsion simulation system is housed in a right circular cylinder of stainless steel and copper, to which the instrumented parts simulating the model external lines are rigidly mounted. For test CH79 the model was mounted on a thrust stand in the middle of the "lunar plane" of the test chamber firing vertically upward along the chamber axis. The propellants were gaseous hydrogen and oxygen.

The model lines simulate the CML of orbiter vehicle 102 aft of the base heat shield. Scaled components include the body flap, CMS/RCS pods and CMS engine nozzles, vertical tail, base heat shield, and SSME nozzles. The nozzles, both MPS and CMS, are correctly scaled internally (i.e., throat diameters, exit diameters, lengths, and internal contours). External nozzle contours are not precisely scaled because the nozzle wall thicknesses have been deliberately increased to allow for flush mounting of external instrumentation while preserving the ability to withstand the heat and pressure stresses of repeated model firings. The vertical tail is accurate as to planform and location, but simulates the undeflected rudder condition only. The body flap may be attached either in the nominal ( $\delta = 0^{\circ}$ ) position or deflected twenty degrees ( $\delta = +20^{\circ}$ ). All data taken during test CH79 were with the body flap in the undeflected position. A heat protective device, referred to as the flow

diverter, was mounted to the central part of the base heat shield. The general arrangement of the model is shown in Figure 1.

# Propulsion Simulation System

Physically the propulsion simulation system consisted of a right circular cylinder of stainless steel and copper with internal passages for the flow of gaseous propellants and combustion products and external provisions for the attachment and support of model components and instrumentation harnesses and connectors. The upstream section of the propulsion simulation system attached to a flange or adapter which may be used to mount the model in any desired orientation.

Gaseous propellants (hydrogen and oxygen) were stored in external containers called charge tubes at the desired pressure (nominally 3000 psi) until model operation was required. The charge tubes are essentially stainless steel pipes of approximately one-inch internal diameter and lengths sufficient for an expansion wave reflection time exceeding 80 milliseconds. This wave time can be obtained with 02 and H2 charge tube lengths of 50 and 200 feet, respectively. The charge tubes were folded for installation alongside the model in the test chamber.

The propellant gases were supplied to the propulsion simulation system through a bipropellant autovalve attached to the upstream face of the mounting flange. The autovalve rapidly opens and closes the two propellant control valves, which are yoked together, to admit the propellant gases at pressures up to 3000 psi. The control valves remain

open for a predetermined time interval, normally less than the wave time of the charge tubes. The duration of the "valves open" interval is preset, within close limits, by manual adjustment of time delay circuit parameters. The timing controls, together with other switches and controls, are located on the firing control panel. Energy for actuation of the autovalve is supplied by a regulated source of gaseous nitrogen at 3000 psi. The nitrogen is admitted to the open/close sides of the operating piston through solenoid-operated Valcor valves. Because continuous burning of any large fraction of the propellant stored in the charge tubes would destroy the model, redundancy is provided in both the electrical signals and the nitrogen source (Valcor valve) to the "close" side of the operating piston. In the event that gas leakage past the bipropellant valves is sufficient to make long test chamber pumping times necessary, a pre-scored copper diaphragm may be installed between the autovalve and the flange. Operation of the bipropellant valves causes rupture and petalling of the weak diaphragm in the gas passages, and model firing operation is the same as without the diaphragm. It was not necessary to use the diaphragms during this test.

Within the propulsion simulation system, the propellant gases flowed through metering devices (venturis) before entering the injector passages. The venturi flowmeters are designed to remain choked under nominal model operating conditions. Upon autovalve opening, the charge tube gases are

admitted, at essentially the loading pressure, to the venturi inlets.

Venturi inlet pressures then remain constant until the reflected expansion shock waves generated by autovalve opening, return from the far end of the charge tubes. Under these conditions (choked venturis at constant inlet pressure), the propellant weight flow rates remained constant throughout the wave time of the charge tubes unless the autovalve closed prior to the wave return.

Propellant flows to the Main Propulsion System (MPS) were routed axially through the model. Downstream of the venturis the propellants entered the passages of a single injector, which mixed the fuel and oxidizer in a central combustion chamber, from which the burning gases were led off through separate passages to the three SSME nozzles. Ignition of the propellants in the central combustion chamber was accomplished with an automotive type spark plug. The timing of spark occurrence was controlled through adjustment of a potentiometer in the spark timing circuit. Closure of a microswitch during the autovalve opening stroke energized the spark timing circuit.

A set of metering venturis permitted metered (choked) flow to the MPS engines during three-engine firing simulation. The set of venturis was scaled to deliver weight flows at the nominal O/F ratio of 6 when the charge tubes were loaded to approximately the same pressure.

Two sets of SSME firing nozzles were provided. One set simulated such external nozzle features as the "hatband" stiffeners and coolant

distribution pipes and manifolds. All four nozzles in this set bore heat transfer instrumentation; only three nozzles were used for test CH79. The other set of four nozzles had smooth external walls; three were non-instrumented, and one was instrumented and used for defining gimballing limitation criteria. Both sets of nozzles faithfully reproduced the internal profiles of the full-scale engine nozzles, but wall thickness was not accurately scaled in either case. One instrumented, smooth-walled, non-firing nozzle was provided for simulated engine-out conditions; it was not used for test CH79.

Two sets of CMS nozzles were provided: one firing and one nonfiring. Both non-firing nozzles had heat transfer gauges installed;
only the left firing nozzle was instrumented. The firing nozzle
internal profiles were correctly scaled, but the wall thicknesses
were increased to permit flush-mounting of the external thin-film gauges
and to provide strength and rigidity. Non-firing nozzles were installed;
the CMS combustion system was not used for test CH79.

Interchangeable gimbal blocks were used to gimbal the MPS nozzles in discrete increments. The MPS nozzles could be gimballed in pitch, yaw, or a combination of pitch and yaw up to a total gimbal angle of 11 degrees. Gimballing for the lower SSME nozzles was generally defined from the actuator null position (+10° pitch, 3.5° yaw outboard). The only exceptions were entries 21 and 22 where gimballing was defined from parallel yaw (+10° pitch, 0° yaw).

Model 65-0 was distinguished from its predecessor, Model 25-0, by a redesign of the propulsion simulation system to reduce the firing steady-state response time. Model stabilization time (steady-state combustion chamber pressure achieved) appeared to be approximately 12-14 milliseconds for the MPS with three engines firing.

### Model Nomenclature

The following nomenclature is used to describe model components for the orbiter 102 (Vehicle 5) configurations:

B60	basic fuselage of vehicle 102 orbiter per Rockwell drawings
M <sub>18</sub>	orbital maneuvering system pods per Rockwell drawings
v <sub>5</sub>	vertical tail per Rockwell drawings
F14	body flap, per Rockwell drawings
N <sub>93</sub> ,26	main propulsion system nozzles per Rockwell drawings
N8,90	orbiter maneuvering system nozzles per Rockwell drawings

Full-scale and model-scale dimensional data for the components of Model 65-0 are presented in Table III.

A more complete description of the model will be found in References 1 and 2.

#### INSTRUMENTATION

#### Pressure and Heat Transfer

Instrumentation on the external (lines) model part of model 65-0 consisted of static pressure taps and thin-film heat transfer gauges. Static pressures were measured with low-range piezo-electric pressure transducers mounted inside the model as close to the pressure orifice as possible. A small piece of flexible tubing was placed between the pressure transducer and orifice to attenuate acceleration when the model engines were fired. Thin-film heat transfer gauges were total gauges measuring a surface temperature-time history due to both convective and radiative heat transfer.

The instrumentation on model 65-0 used for test OH79 is presented in Table IV and Figure 2. Table IV lists the instrumentation on each model part and categorizes it according to instrumentation pattern; Figure 2 illustrates the instrumentation locations. The instrumentation used is summarized below and itemized on Figure 2.

Standard Base Heat Shield (Instrumentation Patterns 1, 2, 4, 7, 8):

Thin-film heat transfer gauges 128

Piezo-electric pressure transducers 20

Tile Gap Base Heat Shield (Instrumentation Pattern 6):

Thin-film heat transfer gauges 88

Piezo-electric pressure transducers 2

#### Reference

Reference instrumentation consisted of five internal static pressure

### INSTRUMENTATION (Continued)

measurements, five thermocouple measurements, and six discrete event signals.

Internal static pressures were measured with high-range piezoelectric pressure transducers. The pressures were hydrogen and oxygen
venturi, hydrogen and oxygen injector, and SSME combustion chamber. All
pressures were used to monitor the model firing. In addition, the
venturi and combustion chamber pressures were used to calculate propellant weight flow rate and propulsion simulation system combustion
efficiency.

Five thermocouples were mounted on the model to monitor temperature during repeated firings of a chamber entry. Two of the five were on opposite edges of the base heat shield, and their output before model firing was used as the initial thin-film gauge temperature for data reduction purposes. A third thermocouple was mounted on the aft wall of the combustion chamber. The remaining two thermocouples were mounted in the hydrogen and oxygen charge tubes.

The six discrete event signals were voltage signals used as cues for data processing operations and for monitoring the model firing sequence. The signals were:

- 1. Reference time (To)
- 2. Autovalve open signal (T1)
- 3. Autovalve redundant close signal (T2)
  - 4. Autovalve primary close signal (T3)

# INSTRUMENTATION (Continued)

- 5. Spark ignition signal (T<sub>5</sub>)
- 6. Autovalve open/close trace (To)

### Sensor Description

Piezo-electric transducers responded only to pressure changes.

Piezo-electric materials inside the transducer sensed pressure changes on the transducer diaphragm. Each transducer was compensated for acceleration by a diaphragm wired opposite to the active diaphragm. Piezo-electric transducers were PCB type. High-range transducers were PCB Piezotronics model lllA22 dynamic pressure transducers rated for 5000 psid maximum. Low-range transducers were PCB Piezotronics model 103A sound pressure transducers, rated for 2 psid maximum.

The total heat transfer gauge was a thin-film gauge consisting of a thin resistance film of platinum fused to a Pyrex substrate (#7740 Pyrex). Silver tabs were fused to the platinum film terminals. Electrical connections were made to the silver with soft solder. The platinum film was insulated from the airstream by a thin dielectric coating of magnesium fluoride. All thin-film gauges measured the change in local surface temperature. The total gauge responded to both convective and radiative heating.

Thin-film gauges were contoured as required to match model curvature. Contouring was required on the hatband nozzles.

All thin-film gauges were bonded in place. Piezo-electric transducers were also bonded in place except for the high-pressure PCB's which

#### INSTRUMENTATION (Concluded)

were threaded.

Further descriptions of the piezo-electric transducer and total heat transfer gauge can be found in Reference 3.

Figures 3 through 7 are various views of the base of the model showing excellent visualization of the heat transfer instrumentation. The small piezo-electric transducer pressure orifices are also visible on some views. Figure 3 shows overall views of the model illustrating heat transfer gauges on the base heat shield, body flap, OMS, and vertical tail. Figure 4 shows the heat transfer gauges on the SSME hatband nozzles. Heat transfer gauges on the SSME smooth-wall nozzle are shown on Figure 5. Figure 6 shows heat transfer gauges on the flow diverter mounted in place on the center base heat shield. Tile gap, base heat shield, and body flap heat transfer gauges are shown on Figure 7.

#### TEST FACILITY DESCRIPTION

The Thermal Vacuum Chamber A of the NASA Johnson Space Center's Space Environment Simulation Laboratory is a large man-rated thermal vacuum chamber. The clear area inside the cold walls is 55 feet in diameter and extends 90 feet above the "Lunar Plane," the rotatable floor which supports the test articles and associated equipment. The internal free volume is approximately 350,000 cubic feet. The facility vacuum system is capable of bringing the test chamber to a simulated altitude of 300,000 feet (5 x  $10^{-14}$  torr) in approximately four and one-half hours.

#### TEST PROCEDURES

#### Installation

The model was mounted on a flange/adapter bolted to a thrust stand in the center of the test chamber floor (lunar plane). The model was oriented so that the MPS engine plumes were directed vertically upward along the test chamber centerline. The propellant charge tubes, of schedule 80 stainless steel pipe, were folded within a rack to a package approximately 39 feet long. The accommodation of this package in the test chamber required positioning the charge tubes alongside the thrust stand and delivering propellants to the model from what had originally been the "fill" ends of the charge tubes. One of two pressurized containers near the model housed the "timer chassis," on which were mounted the model firing control electronic components and timer relays. The other container housed the model spark coils of other ignition system components. The physical arrangement of the model, thrust stand, charge tubes, and associated equipment in the test chamber is shown in Figure 8.

The instrumentation leads from each model component (nozzle, section of base heat shield, body flap, etc.) were grouped into bundles 36 inches in length with one half of a Cannon strip connector on the far end. The mating halves of the Cannon strip connectors were in turn attached to wire bundles 12 feet in length, which terminated at large Deutch connectors at the lunar plane beneath the model. From this point, facility wiring conducted measurement signals to amplifiers, signal conditioning equipment, and FM/FM tape recorders. The strip connectors and wire bundles are shown in Figure 9.

### Installation (Continued)

Control panels for regulating gas supply to the charge tubes and autovalve were mounted near the exterior wall of Chamber A. The panels regulated pressure, vent, and purge of the hydrogen and oxygen charge tubes; pressure and vent of the autovalve; and pressure to the pressurized containers. An assortment of gases was supplied by bottles located near the panels. The autovalve and pressurized containers used only nitrogen. The oxygen charge tube used oxygen for model firings and nitrogen for purging and leak checking. The hydrogen charge tube used hydrogen for model firings, nitrogen for purging, and helium for leak checking. Figure 10 shows the gas line arrangement inside the chamber as the lines extend away from the thrust stand to the chamber wall. Figure 11 shows the gas control panels outside the chamber where the lines terminate.

Panels for controlling the model firing sequence were in the control room. One panel started the firing sequence while two other panels controlled the timer relays and spark ignition system housed in the two pressurized containers.

#### Calibrations

All new thin-film heat transfer gauges were calibrated prior to installation in the model. Gauge resistance change with temperature was measured to determine a sensitivity factor,  $K_{\text{C}}$ . The temperature range was nominally  $70^{\circ}\text{F}$  to  $150^{\circ}\text{F}$  with three points being measured. Used thin-

film gauges initially installed in the model for a previous test in Chamber A were not replaced or recalibrated if they were in good operating condition. The original calibrations were retained.

PCB piezo-electric pressure transducers were calibrated prior to installation in the model. Low-range PCB's, 0 to 2 psid, were calibrated at six points between 0 and 1.0 psi. High-range PCB's, 0 to 5000 psid, were calibrated at six points between 0 and 1900 psi. Because high-range PCB's were threaded in place, an unwanted stress imposed on the transducer during installation could alter the bench calibration. Therefore, "dead-end" calibrations with the nozzle exits blocked were performed on the high-range PCB's to guard against excessive change and to slightly alter the bench calibration if desired.

#### Operating Procedure

Test preparation and test operation activities were conducted in accordance with the detailed test procedures for the OH79 base heating test (Reference 4). During a chamber entry, the procedures were followed step by step from the start of pumpdown until the chamber returned to atmospheric conditions.

Because multiple SSME firings were possible with the surface gap spark plug, refurbishment of the ignition system did not dictate the number of model firings during a chamber entry. In the past, SSME firings had to be limited to approximately ten due to heat deterioration of the SSME gimbal block O-rings; this was not a factor during test

OH79 because of the relatively small test program. The number of SSME firings per chamber entry was simply determined by the proposed test altitude survey at each model configuration.

Four altitude conditions were required for test CH79 (see Table 1). For each model configuration, two, three, or four altitudes were scheduled to be surveyed. The number of SSME firings sometimes exceeded the number of scheduled altitude conditions. The primary reason to repeat SSME firings throughout the test was to improve data acquisition gain settings to obtain better quality data. The maximum SSME firings were 7 on Entry 15.

The order in which altitude data were obtained during a chamber entry remained flexible throughout the test program. Generally, the initial data were obtained at the lowest altitude or the lowest altitude where heating rates were significant. Subsequent data were obtained at altitudes in ascending order as long as the smooth flow of progress to reach the highest altitude was not significantly interrupted. Data not obtained on the ascending altitude curve could be obtained on the descending curve. Approximately four hours minimum was required to reach the highest altitude.

Pressures listed in Table 1 representing the test altitude conditions are one-half of the actual altitude pressure. Actual altitude pressures were determined by Reference 5. With the model SSME's operating at one-half full-scale chamber pressure, and Chamber A operating at one-half actual altitude pressure, the scaled SSME plume flow field was

duplicated.

Two setup sheets were used to dictate the test activities for each day. The sheets contained pretest information, i.e., model configuration, model control pressures, planned test conditions, timer settings, etc., and post-test information, i.e., actual test conditions, actual model control pressures, IRIG time, model temperatures, etc. An example of the two setup sheets is shown in Table V.

The "descriptor" on Form I of the setup sheets is a nine-character code describing each model firing. Each test descriptor is listed in the run schedule in Table II. Each character of the "descriptor" is determined from the model and test configurations listed in Table VI.

control panel. When actuated, the switch set in motion a series of timing relays to operate the autovalve for proper charge tube gas flow to the combustion chamber (timing event signals T1, T2, T3) and to ignite the gas in the combustion chamber (timing event signal T5).

Timing event signal T5, which controlled the surface gap spark plug, was by far the most critical. Autovalve operation at this point, the fourth test of a base heating test series with this basic model, has become reliable and predictable making the T1, T2, and T3 timer settings a matter of routine. T5, on the other hand, must be set to actuate the spark within two to three milliseconds after charge tube gas flow reaches the combustion chamber, and then the time tolerance for spark occurrence

is less than one millisecond for safe and reliable SSME operation. If the spark occurs too soon, the combustion chamber may contain insufficient gas mixture or insufficient pressure for ignition. If the spark occurs too late, the combustion chamber may contain too much pressure before ignition causing overpressure during ignition which could result in structural damage to the model. Standard practice was to ignite the cold gas mixture before the pressure exceeded 100 psi. Because of the critical timing of the charge tube gas flow and spark, the reliable autovalve operation was a significant plus factor. Spark occurrence was also reliable once a timer setting had been established. Timer setting changes were not necessary unless the spark plug was replaced or unless the microswitch which actuated the T5 timing event was replaced. The spark plug was changed twice during the test program, prior to chamber entries 11 and 26, respectively. These two occasions were not required changes but were precautions to prevent erosion and subsequent welding of the spark plug threads to the steel helicoil insert in the combustor housing. The microswitch did, however, require replacement on several occasions. There were two microswitches actuated when the autovalve opened: one initiated the primary closing timer relay, and one initiated the spark timer relay. If either one partially broke during repeated use, a new set was installed. When either the spark plug or microswitch was replaced, a new T5 timer setting had to be established by comparing the spark event with the combustion chamber pressure trace. Typical examples of the pressure and

timing event data obtained to monitor SSME operation are shown in Figures 12 and 13.

Model refurbishment between chamber entries generally consisted of updating the model configuration and instrumentation checkout. Model configuration changes centered around the SSME gimbal pattern which was changed for almost every entry. At the same time, other required configuration changes and maintenance were completed, i.e., SSME nozzle rotation, SSME engine adapter 0-rings, Pc transducer diaphragm insulation tape, flow diverter, etc. Each time the SSME gimbal pattern was changed, a low-pressure leak check was performed by plugging the SSME nozzle throats and pressurizing the model with approximately 150 psi helium to detect leaks around the gimbal block Marmon clamps. Each time the SSME chamber pressure transducer was removed to replace or install new insulation tape, or each time the spark plug was replaced, a high-pressure leak check was performed by blocking the aft end of the SSME gimbal blocks and pressurizing the model with helium at approximately 400 psi. Instrumentation checkout between chamber entries consisted of a "quick fix" effort to correct noisy channels or thin-film gauges and piezo-electric pressure transducers that showed no response. A faulty amplifier was replaced or wiring was repaired when feasible, but faulty thin-film gauges or intricate wiring problems were ignored. When a thin-film gauge or its wiring were determined to be beyond repair, a substitute gauge was patched into the data acquisition system. Low-range piezo-electric pressure transducers

were reliable enough not to warrant replacement throughout the test. Of the high-range piezo-electric pressure transducers, only the SSME combustion chamber transducer required replacement on one occasion. Model refurbishment did not delay any chamber entry throughout the test program except after the first entry when numerous instrumentation and data acquisition problems required checkout.

### Data Acquisition

Three types of data acquisition systems were used for test OH79:
FLEX, FACT, and Vidar.

FLEX allowed visual display in the control room of selected model and Chamber A parameters for easy analysis. The parameters were:

Autovalve operation pressures

Charge tube pressures

Charge tube temperatures

Model base thermocouple temperatures

Model system power supply voltages

Chamber A pressure

FACT is the facility's "Fast Automatic Circuit Tester" equipment used to record steady-state thin-film gauge data. FACT is capable of recording up to 144 individual channels of data; however, a maximum of only ninety-four were used for test OH79. The steady-state data measurement consisted of thin-film gauge resistance plus the line resistance from the gauge to the FACT equipment. FACT data were recorded before each model

firing. A final FACT recording was also obtained after the last model firing of a chamber entry. A minimum of twenty minutes elapsed between model firing and FACT recording to allow the model thin-film gauges to stabilize. FACT data were used for data reduction and to assess thin-film gauge integrity. A good thin-film gauge maintained relatively constant resistance.

Vidar is an analog system for recording data during model firing.

Two Vidar systems were used for test OH79. Vidar 1 was a 60-channel,

100-millivolt, full-scale system with 12 tracks of 5 channels each. Its
data consisted of:

- 31 to 35 thin-film gauge measurements
  - 2 or 20 low-range pressure measurements
  - 1 timing event  $(T_0)$
- 2 IRIG time channels

Vidar 2 was a 78-channel, 500-millivolt, full-scale system with 13 tracks of 6 channels each. Its data consisted of:

- 53 to 59 thin-film gauge measurements
- 5 high-range pressure measurements
  - 6 timing events
    - 2 IRIG time channels

Pressure transducer signal conditioning was provided by a 110V multi-channel power unit built specifically for the PCB transducer. The

power supply unit provided 22V and 12mA current excitation for the transducers. Being highly sensitive, approximately 1500 mV/psi, the low-range PCB transducers did not require additional amplification. High-range PCB transducers with a sensitivity of approximately 1 mV/psi also did not require amplification, but they did require a voltage divider in the circuits because their output ranged from 1500 mV to 3000 mV. Venturi and injector transducer outputs were divided by a factor of six (3000 mV output = 500 mV full scale); SSME chamber pressure transducer output was divided by a factor of four (2000 mV output = 500 mV full scale). PCB transducer circuit time constants were approximately 3 seconds for the low-range transducers and approximately 5 seconds for the high-range transducers.

Thin-film gauge signal conditioning consisted of signal conditioning circuitry requiring 12V excitation and amplifiers to boost the signal  $(\approx \text{lmV}/\text{OF})$  for Vidar recording. The circuit time constant was 2.4 seconds. Amplifiers for the two Vidar systems were as follows:

Vidar 1 (Dual Amplifiers):

Pre-Amp Gain Settings = 0.01, 0.03, 0.1, 0.3, 1, 3, 10

Post-Amp Gain Settings = 0.1, 1, 10, 100

Vidar 2 (Single Amplifier):

Gain Settings = 1, 2, 5, 10, 20, 50, 100, 200, 500, 1000 Amplifier bandwidth was set at 10K  $\rm H_{Z}.$ 

Data acquisition equipment is shown in Figures 14a through 14c.

Figure 14a shows the FACT equipment in the center background. Figure 14b shows the two Vidar systems with the visicorder playback. Figure 14c shows the amplifiers and signal conditioning equipment; amplifiers for Vidar 1 are on the left, signal conditioning equipment is in the middle, and amplifiers for Vidar 2 are on the right.

Amplifier gains were established for the initial entry of each instrumentation pattern and then were updated as required between model firings or chamber entries to improve the signal-to-noise ratio for better quality data. Gains were changed to raise the signal out of the noise level or to eliminate or prevent saturation. It was common practice to have two or three gain patterns for each chamber entry and a new gain pattern at the start of each entry.

Six instrumentation patterns were developed for test CH79. They were determined by model configuration or model geometry. The six patterns are outlined in Table VII.

Instrumentation configurations were designated by two digits. The first digit was a number signifying one of the instrumentation patterns listed in Table VII. The second digit was a letter signifying a particular amplifier gain pattern for that particular instrumentation pattern.

SSME nozzles and the orientation of their instrumentation varied with instrumentation pattern. Four SSME nozzles were used throughout the test program: drain line, #1, #3 and smooth wall. The SSME nozzles and

#### TEST PROCEDURES (Continued)

instrumentation orientation for each instrumentation pattern are shown in Figures 15A through 15e. The figures are viewed looking forward along each nozzle axis.

Each engine-mounted heat shield (eyeball, see Figure 2a) was rigidly attached to the SSME nozzle. The basic instrumentation orientation of each engine-mounted heat shield at the #1, #2, and #3 SSME nozzle positions is as shown in Figure 2a. This basic orientation was maintained throughout instrumentation patterns 1, 4, 6, 7, and 8. Because repeat data were not essential, the engine-mounted heat shields were allowed to rotate with the nozzles for instrumentation pattern 2, i.e., whatever angle the SSME nozzles were rotated away from the instrumentation pattern 1 orientation, the engine-mounted heat shields were rotated by an equal amount. Engine-mounted heat shield instrumentation orientation for instrumentation pattern 2 is shown in Figures 16a and 16b.

Instrumentation pattern changes usually required switching of thinfilm gauges only. An exception was pattern 6 where low-range PCB transducers were also eliminated. Unless new model parts were installed,
thin-film gauge switching was accomplished at the input to the signal
conditioning units. The output of the signal conditioning units was then
patched to the correct FACT and Vidar system channels if changes were
required. This switching procedure applied to patterns 1 and 2 where
model configuration hardware did not change. Patterns 4, 6, 7, and 8,
where new model hardware was added or installed, also required patching

#### TEST PROCEDURES (Continued)

at the Cannon strip connectors inside Chamber A. Spare cables were used whenever possible to eliminate unnecessary work. Whenever any thin-film gauge or PCB transducer patching changes were made, a continuity check from the gauge or transducer to the Vidar systems insured proper hookup.

Thin-film gauge line resistances were determined by inserting a shorted connector in place of the gauge at the Cannon strip connectors and recording the resultant line resistance on the FACT system.

Data were reviewed immediately after each model firing to:

- 1. Verify satisfactory model operation
- 2. Verify sufficient data and their integrity

  Either selected or all Vidar tracks could be immediately played back on

  Visicorder upon request. Tracks from Vidar 2 containing model high-range
  internal pressure and event data were received first to verify model

  operation. Then, all or selected tracks from both Vidars were received

  to verify thin-film gauge and low-range pressure data. Vidar playback

  data, as a rule, spanned one inch full scale, i.e., 100 mV or 500 mV was

  equal to a one-inch deflection. Because of the need for increased

  sensitivity, hydrogen venturi, oxygen venturi, and SSME chamber pressure

  playback data were spanned to 3.9 inches full scale. Standard practice

  was to review all Vidar channels of the first firing of each entry, and
  thereafter select three or four thin-film gauge and low-range pressure

  data tracks for review. If data review was not complete by the time

  the next ascending altitude was reached, the model firing was skipped,

# TEST PROCEDURES (Concluded)

and the chamber proceeded to the next altitude. At the highest altitude of an entry, all playback data were reviewed before descending. Any data missed during ascent or any data requiring repeat were obtained on descent to atmospheric conditions.

#### DATA REDUCTION

### Chamber A Pressure

Measured Chamber A internal pressure was converted to units of Torr  $$(\mbox{mm}\mbox{ of } H_{\mbox{\scriptsize g}})$$  by the FLEX data system for display in the control room.

# Thermocouples

Model charge tube and base thermocouple measurements were converted to degrees Fahrenheit by the FLEX data system for display in the control room.

#### Data Reduction Procedures

Routine procedures, equipment, and software programs by which the Vidar analog data were converted to digital data and subsequently processed into the desired format are detailed in Reference 6. The computer program (SOBHR) for calculating final reduced data from the digital data is documented in Reference 7.

#### A-D Conversion

Vidar analog data were converted to digital data for storage on tape. Each Vidar analog channel was processed at 2000 samples per second. The full-scale range of each channel was equivalent to 2000 counts.

#### Millivolt Data

Digital count data were converted to units of millivolts by Equation (1).

(1) 
$$mV = \frac{(FS-ZERO)(RAW-CLO)}{CHI - CLO} + ZERO$$
 (millivolts)

#### where:

mV = millivolt value

FS = millivolt equivalent to high calibration level

ZERO = millivolt equivalent to low calibration level

RAW = digital count value

CLO = low calibration count value

CHI = high calibration count value

High and low calibration signals were generated on each Vidar tape for each model firing within one hour before the firing.

#### Tare Correction

Immediately following reference time,  $T_0$ , forty data points were averaged and used as a tare correction for each data point in the data processing interval. The forty data points spanned 20 milliseconds of time (0.5 milliseconds per data point). The tare correction was applied to all pressure and thin-film gauge data; event signals did not require data processing.

#### Code Sheets

Various parameters and preliminary data were input by cards to the SOBHR data processing program. These parameters and data were supplied on "code sheets" for card key punching. Code sheets were required for each model firing. The basic code sheet information consisted of:

 Time information - data processing time interval, data tabulation time interval, data averaging time interval, etc. (Time information was extracted from Vidar playback model operation pressure and event data.)

- 2. Model performance coefficients.
- 3. Header information.
- 4. Pressure conversion from millivolts to psi.
- 5. Thin-film gauge temperature conversion from millivolts to OF.
  - 6. Thin-film gauge gain setting information.
  - 7. Pressure transducer and thin-film gauge circuit time constants.

### Voltage Signal Correction

Pressure transducer and thin-film gauge electronic circuits were subjected to a typical RC circuit discharge rate depending on the time constant of the circuit. As an example, a 2-second circuit time constant will reduce an analog voltage response by approximately 5 percent in 100 milliseconds. To correct for any voltage signal loss, Equation (2) was applied to all pressure transducer and thin-film gauge measurements before final data processing.

(2) 
$$mVc(t_n) = mVc(t_{n-1}) + mV(t_n) - mV(t_{n-1}) e^{-\Delta t/\tau}$$
 (millivolts)

where:

mVc = corrected voltage

mV = actual voltage measurement

t = time at which voltage is being corrected

n = number of time intervals from o to t

 $\Delta t = t/n = data sampling period (\Delta t = 0.5 milliseconds)$ 

 $\tau$  = RC circuit time constant

### Average Data

Pressure and heat transfer data were averaged over a time interval corresponding to stable model operation and peak level of sensor output to obtain a steady-state value. The averaging interval always spanned 13 milliseconds or 26 data points during the last half of SSME operation.

### Low-Range Pressures

Low-range PCB transducer measurements of base pressures during model firing were reduced according to Equation (3).

(3) 
$$P = \Delta P + P_{ref} + PCOR$$
 (Mpsia)

where:

(4) 
$$\Delta P = mVe/(\frac{S}{1000}) + OFF$$
 (Mpsi)

(5) 
$$PCOR = \frac{P_A \quad psi}{51.7 \text{ Torr}} \times 1000 \quad (Mpsia)$$

 $\Delta P$  = differential pressure due to model firing

Pref = reference pressure

PCOR = pressure correction

OFF = transducer offset

PA = Chamber A internal pressure, Torr

mVc = millivolt output of transducer (corrected)

S = transducer bench calibration, mV/psi

For all low-range pressure data processing,  $P_{ref}$  and OFF were zero; PCOR calculated by Equation (5) was used as the actual transducer reference pressure. Therefore, Equations (3) and (4) are simplified to:

(6) 
$$P = \Delta P + PCOR$$
 (Mpsia)

(7) 
$$\Delta P = mVc/\left(\frac{S}{1000}\right)$$
 (Mpsi)

# High-Range Pressures

High-range PCB transducer measurements of model internal operating pressures were reduced according to Equation (8).

(8) 
$$P_0 = \Delta P_0 + P_{ref} + PCOR$$
 (psia) where:

(9) 
$$\Delta P_0 = mVc/S + OFF$$
 (psi)

Terms of Equations (8) and (9) are as defined in the preceding section. Bench calibration sensitivity, S, is corrected to account for installation effects. For all high-range pressure data processing, Pref was zero; OFF was zero for all model firings except for the SSME chamber pressure transducer during entries 28 and 29, where a large transducer zero shift (see Results and Discussion) was accounted for by OFF.

PCOR, Equation (5), was used as the actual reference pressure for the high range transducers. Noting that PCOR is 1000 times the actual Chamber A pressure in units of psia, a slight error is introduced into Equation (8). Maximum error is approximately 2.4% at 120K feet; minimum error is approximately 0.01% at 240K feet.

Equations (8) and (9) can now be simplified to:

(10) 
$$P_0 = \Delta P_0 + PCOR$$
 (psia)

(11) 
$$\Delta P_0 = mVc/S + OFF$$
 (psi)

# Heat Transfer Rates

Thin-film gauge output was a surface temperature time history which is analogous to homogeneous one-dimensional, semi-infinite slab theory for unsteady heat conduction. The numerical technique used to extract instantaneous heating rates from the surface temperature-time history, i.e., the solution to the unsteady, one-dimensional heat conduction equation for a semi-infinite body, is described in Reference 8.

Three heat transfer rates were calculated from a thin-film gauge temperature time history:

- 1. Constant heating rate (Equation (12))
- 2. Instantaneous heating rate (Equations (13), (14), and (15))
- 3. Normalized heating rate (Equation (16))

Normalized heating rates were used for the tabulated summary data.

(12) 
$$\dot{q}_{cn} = \frac{\pi K \Delta T_n}{2 \sqrt{t_n}}$$
 (BTU/ft<sup>2</sup>-sec)

(13) 
$$\dot{q}_n = K \left[ \frac{\Delta T(t_n)}{\sqrt{t_n}} + \sum_{i=2}^{n-1} \left[ \frac{\Delta T(t_n) - \Delta T(t_i)}{\sqrt{t_n - t_i}} - \frac{\Delta T(t_n) - \Delta T(t_{i-1})}{\sqrt{t_n - t_{i-1}}} \right] \right]$$

$$+2 \frac{\Delta T(t_i) - \Delta T(t_{i-1})}{\sqrt{t_n - t_i} + \sqrt{t_n - t_{i-1}}} + \frac{\Delta T(t_n) - \Delta T(t_{n-1})}{\sqrt{\Delta t}}$$

for n = 1,

$$(14)$$
  $\dot{q}_1 = 0$ 

For n = 2,

(15) 
$$\dot{q}_2 = \frac{\pi K \Delta T_2}{4\sqrt{t_2}} \qquad (BTU/ft^2-sec)$$

(16) 
$$\overline{q}_{ss} = \frac{R_p^{0.8}}{(l-j)+1} \sum_{n=j}^{\ell} \dot{q}_n$$
 (BTU/ft<sup>2</sup>-sec)

Parameters in Equations (12) through (16) are defined as follows:

K = thin-film gauge substrate properties (Equation (17))

 $\Delta T$  = surface temperature change from the temperature-time history (Equation (18))

t = time at which heating rate is being determined

 $\Delta t = t/n = data sampling period (\Delta t = 0.5 milliseconds)$ 

n = number of time intervals from o to t

N = upper limit of n

i = iteration variable

l, j = averaging index interval

Rp = ratio of nominal to average SSME chamber pressure

Thin-film gauge substrate properties were determined from a thirdorder curve fit of Figure 17. The resulting equation is:

(17) 
$$K = \frac{1}{\sqrt{\pi}} \left( \frac{\sqrt{\rho_{ck}}}{\sqrt{\rho_{ck}}} \right) \sqrt{\rho_{ck}}_{70} = \frac{1}{\sqrt{\pi}} \left( 6.94848 \times 10^{-2} + 6.4165929 \times 10^{-5} T_{a} \right)$$
$$- 6.8729213 \times 10^{-8} T_{a}^{2} + 2.671248 \times 10^{-11} T_{a}^{3}$$
$$(BTU/ft^{2}-sec^{1/2}-o_{F})$$

where

 $\rho$  = density

c = specific heat

k = thermal conductivity

Ta = TCOR = model steady-state temperature prior to firing (average of base heat shield thermocouples)

Surface temperature change,  $\Delta T$ , was determined by a sliding average of the differential temperature computed by Equation (18).

(18) 
$$\Delta T(t) = mVe \frac{\alpha}{S_g}$$
 (°F)

where

 $\alpha$  = reciprocal of the signal conducting gain

 $S_g$  = gauge conversion to  ${}^{O}F$ 

One characteristic of Equation (13) is that the surface temperaturetime history must be a smooth curve in order to produce a smooth heating rate-time history. A smooth temperature-time history was attained by calculating a sliding average of the actual surface temperature-time history. Equations (19) and (20) were applied three successive times to the data generated by Equation (18) before using the data in heating rate Equations (12) and (13).

(19) 
$$\Delta T(t_1) = \frac{\Delta T(t_1) + \Delta T(t_2)}{2}$$
 (°F)

(20) 
$$\Delta T(t_2....t_n) = \frac{\Delta T(t_{n-1}) + \Delta T(t_n) + \Delta T(t_{n+1})}{3}$$
 (°F)

Gauge conversion,  $S_g$ , used in Equation (18) was calculated by Equation (21).

(21) 
$$S_g = K_T V_{ps} \frac{1000^2}{(1000 + R_L + R_G)(1220 + R_L + R_G)}$$
  $(mV/^{\circ}F)$ 

(22) 
$$K_T = K_{70} (1.018 - 2.59 \times 10^{-4} T_a)$$
 (Ohms/°F)

(23) 
$$K_{70} = \frac{R_G}{\frac{R_C}{K_C} + (T_{a.} - 70)}$$
 (Ohms/°F)

where

 $K_{T}$  = sensitivity at  $T_{a}$ 

K70 = sensitivity at 70°F

 $K_c$  = calibration sensitivity at  $70^{\circ}F$ 

 $R_c$  = calibration resistance at  $70^{\circ}$ F

 $R_G$  = resistance at  $T_a$ 

 $R_{\rm L}$  = line resistance

 $T_a$  = model steady state temperature prior to firing

 $V_{DS}$  = circuit power supply voltage (12V)

Model steady-state temperature,  $T_a$ , was determined from the average of the two thermocouples mounted on the edges of the base heat shield. Gauge resistance was recorded by FACT. Actual FACT data consisted of  $R_{\rm L}+R_{\rm G}$ . Line resistances were recorded by FACT as described in the data acquisition section.

#### Model Performance

Model performance was determined by the SSME nozzle combustion

efficiency which is a ratio of actual to ideal characteristic throat velocity.

$$\eta_{c} = \frac{c^{*}}{c^{*}_{th}}$$

where

C\* = actual characteristic throat velocity

C\*th = theoretical characteristic throat velocity

Actual characteristic throat velocity was computed by:

(25) 
$$C^* = \frac{P_c A_t g}{W_T}$$
 (ft/sec)

where

P<sub>c</sub> = SSME chamber pressure

At = SSME nozzle throat area

g = gravitational constant

 $\dot{W}_{\rm T}$  = total weight flow rate

Theoretical characteristic throat velocity was computed by:

(26) 
$$c_{th}^* = 9397.5 - 305.0r - (39.832r^2 - 505.8664r + 1410.0552) log  $(\frac{P_c}{100})$  (ft/sec)$$

where

r = oxidizer/fuel ratio

Total weight flow rate and oxidizer/fuel ratio were calculated from the individual hydrogen and oxygen weight flow rates as follows:

# DATA REDUCTION (Concluded)

(27) 
$$\dot{W}_{T} = \dot{W}_{O2} + \dot{W}_{H2}$$
 (lb/sec)

(28) 
$$r = \frac{\dot{w}_{O2}}{\dot{w}_{H2}}$$

where

WO2 = oxygen weight flow rate

W<sub>H2</sub> = hydrogen weight flow rate

Oxygen and hydrogen weight flow equations were determined from venturi calibrations. They are:

(29) 
$$\dot{W}_{02} = 8.1526029 \times 10^{-4} P_{02} + 2.0558974 \times 10^{-8} P_{02}^{2}$$
 (1b/sec)

(30) 
$$\dot{W}_{H2} = 1.4813399 \times 10^{-4} P_{H2} - 1.404687 \times 10^{-9} P_{H2}^2$$
 (1b/sec)

where

Po2 = steady-state oxygen venturi pressure

PH2 = steady-state hydrogen venturi pressure

#### RESULTS AND DISCUSSION

Test OH79 data consisted of heating rates and pressures varying as a function of time during model firing. By selecting a time interval to average data, as described in the preceding section, each sensor output during the firing was summarized by a single steady-state value.

Two types of data were received: tabulated and plotted. Tabulated summary data consisted of (1) chamber and model header information, (2) a listing of card inputs to the data reduction program, (3) model performance data, and (4) summary heat transfer and pressure data. Plotted data consisted of the same plus heat transfer and pressure data in engineering units displayed as a function of model firing time. Plotted pressure data were each low-range PCB transducer measurement or each high-range PCB transducer measurement displayed versus model firing time in milliseconds. Plotted heat transfer data were differential temperature, instantaneous heating rate, and constant heating rate from each thin-film gauge measurement displayed versus model firing time in milliseconds.

Analog data were generally of good quality with a high signal-to-noise ratio. Some channels did experience a relatively higher noise level than others or experienced 60-cycle noise, but it usually did not result in data loss or inhibit the steady-state data level. Filtering of some channels by reducing the bandwidth to 1K  $\rm H_Z$  did not appear to improve signal quality. Pressure data at low altitudes (120K and 150K) were mostly noise, possibly caused by acceleration due to the model

#### RESULTS AND DISCUSSION (Continued)

firing into a higher surrounding pressure. At higher altitudes, pressure data were relatively clean with good response.

Model combustion efficiency was usually around 0.90 which is a measure of how well the SSME engines simulated the theoretical characteristic throat velocity. This high combustion efficiency does lend credibility to the SSME plume flow field and to the heating rates and pressures generated by it.

SSME combustion chamber pressure usually fluctuated around the desired value of 1500 psia. Late in the test program beginning with Entry 27, the pressure level decreased to approximately 1200 to 1300 psia with a large zero shift. A new transducer was installed without performing an in-place check calibration. The problem persisted which led to the conclusion that the PCB power supply channel circuit was the problem. Switching to a new channel solved the problem, but transducer output was higher than anticipated probably due to a slight calibration shift during installation. In view of the above, the actual SSME chamber pressure was most likely normal for Entry 27 through Entry 31.

Return waves caused by reflection from the chamber walls were not evidenced in the test OH79 data. Results of the previous test in Chamber A indicated that return waves might be a problem. This was not the case. A negative shift in some of the SSME nozzle heating rate data was experienced, but it could not be linked to return waves. It was attributed to electrical noise.

### RESULTS AND DISCUSSION (Concluded)

Tabulated source data are not supplied with this document but are available through the Rockwell International, STS Aerosciences Department as shown in Appendix A.

Plotted source data are also available through the Rockwell
International, STS Aerosciences Department as shown in Appendix A.

Appendix B contains factors to correct the tabulated summary heat transfer data. Parameter Rp in Equation (16) which is a card input to the data reduction via the code sheets, was in error for all model firings. Rp should be the ratio of nominal to average SSME chamber pressure; actually, the inverse was entered on the code sheets. A correction factor for each model firing to account for this error is presented in Appendix B (corrected data = correction factor x tabulated summary data).

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TABLE I. TEST CONDITIONS

SIMULATED ALTITUDE	CHAM: PRES	BER A SURE
(K ft.)	PSIA X 1000	TORR
120	35.400	1.83
150	10.522	5.44 x 10 <sup>-1</sup>
180	3.346	1.73 x 10 <sup>-1</sup>
240	0.2456	1.27 x 10 <sup>-2</sup>

NOTE: Test conditions are nominal.

SUMMARY
COLLATION
UN NUMBER
K
SET/F
DATA
II.
TABLE

				TABL	TABLE II. D	ATA SET/	HUN NUMBE	DATA SET/RUN NUMBER COLLATION SUMMARY	SUMMAF							
+		,				SPA	SPACE DIVISION	NO		Prepared By:		Pa	Page No.	-	01 2	
lest-	+ 0H79	5			NORTH	AMERICAL	AMERICAN ROCKWELL	LL CORPORATION		Checked By:			Report No.			
					T				T	Dates		We	Model No.			1
-	7	3	Post F	12 12 S	•	^	80	•	01	=	12	Gimb	77	14 ng	15 27	
Dotaset Identifue	Chamber - Entry	Simul 120K	sted 150K	AL+. tu 150K	Jes 240K	Configu	Ration	* Hescaip	Actor	Fattern.	SSME Chomber Tressure	HI SSME	13 V	SSPIE	#3 55ME	Y ME
100	2	7	9	5	4	Para Ilel Pitch	Jaw,	INFA401	OIXB		1500	-50	2 - 5	-3.5	N +	+3.5
200	8	8-	4	, m	2			INFAIOIX	×		-	0 2-	1	-3.5		1
003	4		-	m	2			INFAGOIXB	XB			0			0	+3.5
004	5			-	2			INFAZOIXB	×B			+20	12+	N	+ 0+	+3.5
005	9			-	2			INFA 301X	x B		,	0 5+	+5	-3.5	15+	+3.5
900	7	,	2	2,4	W		9	INFASOIXB	×			-5 +0.7	7-5	-2.5		14.2
100	00		4	2	3			INFAGOIX	×			-	1	-	-5 +	42.8
800	6		2	3	4			INFA701X	1			-2 +O.7	1		1	+4.2
600	10	2	3	4	5	<b>^</b>		INFA POLX		>	>		1		T	+2.8
					J											
010	11		1,4	ю	2	Benga to	Gimbal P Null)	INFA 901X	B	-	1500	0	0	Q	0	0
110	7/		2,5	3	4			INFAADIX	×B			+50	5 + 5	.0	-	0
210	13			1,3	2			INFABOIXB	x B			-50	5-	0	-5	0
013	14			1,3	2			INFAEOI	XB			-5	5 - 5	+5	-5-	5
0/4	/5	1,7	2,6	3	4,5			INFA DOLX	B			+50	+	+5	+51	N
015	16	Ą	5	2,4	3	<b>→</b>		INFACOI	xB	<b>→</b>	<b>&gt;</b>	0	0	+5	0	5
910	17		4	2	M	Flow Bloc	King Davice	4NFA001X	A ×	4	1500	0 0	0	-3.5	+ 0	3.5
017	19			-	2		)	4NFA301X	×A			0 5+	2 + 5	5	+5 +3	3.5
018	20	4	-	2	M			4NFA401	Α×	<b>→</b>	,	-50	-5	-3.5	-5 +	+3.5
	1	200	7.80 K						90			A.	A.		A,	2
*610	12	W		2		Roll Gimb	Gimbal (Smooth	SWF DF01X	XB	00	1500	+ 0	1 10.77	-2.23	2-11.01-	-2.23
020*	22	4	7	2,3		LUB	Wall Nogsle)	1NFEGOIX	IXB	7	<b>→</b>	1-0		15.23/1001-	10.77 +2.23	5.23
3																
							of totale	-						<b>1</b>		
FORM MT	FORM M79-Y-6 REV 1-66															1

1 2   Dataset Chamber   1 2   Jacutifine Cutry   10   10   10   10   10   10   10   1	3 2 51mul 120K	est F ated 150K 2,5	5 12+; tu 150K 3 1,3	NORTH  6  1PS  240 K  4	SPA AMERICAN 7 Configu	SPACE DIVISION  NORTH AMERICAN ROCKWELL	TON ELL CORPORATION  ** Descriptor  ZNFBOOIXB  ZNFB 301XB	Prepared By: Checked By: Date: 11 12 22 22 33 22	12 SSME Chamber Pressure /500	Poge   Report   Rep	Model No. 2. Model No. 2. Model No. 2. Model No. 2. 2. 5. 5. 6. 6. 6. 6. 6. 6. 6. 6. 6. 6. 6. 6. 6.	1 2 2 A O X	25.51 5 55ME 7 5 55ME 7 5 5 5 5 5 5 5 5 5 5 5 5 5 5 5 5 5 5
	- 2	4 2 4 4	N 8 2 - N	w 4 7 7 w	Clock 55,	ME'S 60°	2NFB 401 X 2NFC 401 X 2NFC 001 X 2NFC 301 X	m m m m m	7500	0 0 0 0		10 0 0	1     1
33 30 mpa de de de	angles are	7 7 7			Jan Jan 1988		GNFA 401X1 GNFA 401X1 GNFA 401X1 OUTBOARD			1,0 10		2 2 2 2	7 + + 3.5
X X = 1	2 120K 2 150K 2 180K 2-240K												
» č				<i>&gt;</i>						2 8 3			

### TABLE III. MODEL DIMENSIONAL DATA

MODEL COMPONENT: BODY - B60

GENERAL DESCRIPTION: The body is to the Baseline Definition Space Shuttle

Vehicle Configuration 5, MCR 200, Rev. 7 dated 10/17/74.

MODEL SCALE: 0.040

DRAWING NUMBER: VC70-000002, MDV-70 Baseline IML

DIMENSIONS:	FULL SCALE	MODEL SCALE
Ref. Length	1290.3	51.612
Length IML	1288.4	51.536
Length OML	1293.3	51.732
OML Max. Width, in.	262.7184	10.508
IML Max. Width, in.	260.7184	10.428
OML Max. Depth, in.	248.575	9.943
IML MAX. Depth, in.	246.575	9.863
CML Fineness Ratio	5.1365	5.1365
IML Fineness Ratio	5.1525	5.1525
Area		
Max. Cross-Sectional, Ft. <sup>2</sup> @ X <sub>o</sub> 1463.316	340.82	0.545

# TABLE III. MODEL DIMENSIONAL DATA (Continued)

MODEL COMPONENT: OMS PODS (OML) - M<sub>18</sub> Revised 11/11/75

GENERAL DESCRIPTION: Orbiter maneuvering system pod, short pod for orbiter 102/vehicle 5, MCR 1750 Rl baseline.

MODEL SCALE: 0.040

DRAWING NUMBER: VC70-000002A, VL70-008410, MD-V70

DIMENSIONS:	FULL SCALE	MODEL SCALE
Length, in., including RCS package $(X_0 1311 \text{ to } X_0 1569.64)$	258.64	10.386
Length, in. (X <sub>o</sub> 1311 to X <sub>o</sub> 1511)	200.00	8.000
Max. Width, in. (Xp 304, Xo 1511)	135.546	5.421
Max. Depth, in. (Xp 304, Xo 1511)	74.36	2.974
Area, ft. <sup>2</sup>		
Max. Cross-Sectional @ Xp = 304	59.091	2.363

Supersedes M18 values of 11/25/74 Revision

TABLE III. MODEL DIMENSIONAL DATA (Continued)

MODEL COMPONENT: VERTICAL - V<sub>5</sub>

GENERAL DESCRIPTION: Centerline vertical tail, doublewedge airfoil with rounded leading edge.

MODEL SCALE: 0.040

DRAWING NUMBER: VL70-000095

DIMENSIONS:	FULL SCALE	MODEL SCALE
TOTAL DATA		
Area (Theo.), ft <sup>2</sup> Planform	413.25	0.66120
Span (Theo.), in.	315.72	12.629
Aspect Ratio	1.675	1.675
Rate of Taper	0.507	0.507
Taper Ratio	0.404	0.404
Sweep Back Angles, degrees Leading Edge Trailing Edge 0.25 Element Line	45.000 26.249 41.130	45.000 26.249 41.130
Chords: Root (Theo.) WP Tip (Theo.) WP MAC Fus. Sta. of .25 MAC W.P. of .25 MAC B.L. of .25 MAC	268.50 108.47 199.81 1463.50 635.522 0.0	10.740 4.339 7.992 58.54 25.421 0.0
Airfoil Section Leading Wedge Angle, deg. Trailing Wedge Angle, deg. Leading Edge Radius	10.00 14.920 2.00	10.00 14.920 0.080
Void Area	13.17	0.0211
Blanketed Area	12.67	0.0203

TABLE III. MODEL DIMENSIONAL DATA (Continued)

MODEL COMPONENT: BODY FLAP (OUTER MOLD LINES) F14

GENERAL DESCRIPTION: Orbiter body flap vehicle 5 configuration MCR 200

Rev. 7 "CML" to be used with  $B_{63}$  HL  $X_0$  1532.0  $Y_0$  = 128.0

MODEL, SCALE: 0.040

DRAWING NUMBER: VC70-000002, MDV-70

DIMENSIONS:	FULL SCALE	MODEL SCALE
Total Area, Ft <sup>2</sup>	134.125	5.365
Span (equivalent), In.	238.444	9.538
Inb'd equivalent chord, In.	81.00	3.240
Outb'd equivalent chord, In.	81.00	3.240
Ratio movable surface chord/ total surface chord		
At Inb'd equiv. chord	1	
At Outb'd equiv. chord		Sveep Back
Sweep Back Angles, degrees		
Leading Edge	0.0	0.0
Trailing Edge	0.0	0.0
Hingeline	0.0	0.0
Area Moment (MAC X Total area, Ft.3)	905.343	0.0579
Mean Aerodynamic Chord, In.	81.0	3.240

# TABLE III. MODEL DIMENSIONAL DATA (Continued)

MCDEL COMPONENT: MPS NOZZLES - N93

GENERAL DESCRIPTION: The main propulsion nozzles are laval-bell shaped and are located on the aft planes of the orbiter.

MODEL SCALE: 0.040

DRAWING NUMBER: VC70-000002; VC70-08144; RS009107; 13M15000

DIMENSIONS:	FULL SCALE	MODEL SCALE
MACH NO. Length, in.		
Gimbal Point to Exit Plane Throat to Exit Plane	157.00 121.00	6.280 4.840
Diameter, in.		
Exit (ID)	90.414	3.616
Throat	10.3054	0.412
Area, in. <sup>2</sup>		
Exit (ID)	6420.384	10.272
Throat	83.405	0.133
Gimbal Point (Station), in. Upper Nozzle		
X	1445.000	57.800
Y	0.00	0.00
Z	443.000	17.720
Lower Nozzle		
X	1468.170	58.727
Y	± 53.00	± 2.120
Z (%) 2 (%)	342.640	13.706
Null Position, Degrees Upper Nozzle		
Pitch	16.0	16.0
Yaw	0.0	0.0
Lower Nozzle		
Pitch	10.0	10.0
Yaw	3.5	3.5

# TABLE III. MCDEL DIMENSIONAL DATA (Continued)

MCDEL COMPONENT: MPS NOZZLES - N26

GENERAL DESCRIPTION: MPS nozzle, configuration 2A.

MODEL SCALE: 0.040

DRAWING NUMBER: VL70-000089B

DIMENSIONS:	FULL SCALE	MODEL SCALE
MACH NO.		
Diameter, in. Exit	92.0	3.68
Area, ft. <sup>2</sup> Max Cross-sectional	46.16396	0.7386
Gimbal Point (Station), in. Upper Nozzle, in. F.S. X Y Z	1445.00 0 443.	57.80 0 17.72
Lower Nozzle X Y Z	1468.17 ± 53. 543.36	58. <b>72</b> 7 ± 2.12 21.734
Null Position, Degrees Upper Nozzle Pitch (Pitch ± 11°, Yaw ± 9°)	16.	0 .
Lower Nozzle Pitch (Pitch ± 11°, Yaw ± 9°)	10.	3.5 outb'd

# TABLE III. MODEL DIMENSIONAL DATA (Continued)

MODEL COMPONENT:

NOZZLES - N8

GENERAL DESCRIPTION: Basic OMS nozzle of configuration 2A per Rockwell Lines VL70-008306 and VL70-000089B. Intersection of nozzle exit plane and nozzle centerline at  $X_0$  = 1570.75,  $Y_0$  = + 99.25,  $Z_0$  = 507.25.

MODEL SCALE: 0.040

DRAWING NUMBER: VL70-008306, 000089B, SS-A00092

DIMENSIONS:	FULL SCALE	MODEL SCALE
MACH NO.		n.F HitomaT
Diameter, in.		
Exit	50.0	2.0
Throat	N/A	N/A
Inlet	28.00	0.720
84888.0		
Area, ft. <sup>2</sup>		
Exit	13.635	0.545
Gimbal Point (Station), in. Nozzle		
X	1518.0	60.720
Y	± 88.0	± 3.52
Z	492.0	19.68
Null Position, Degrees		
Nozzle		
Pitch	150491	15°49'
Yaw	± 12°17'	± 12°17'
T CT M	- 1- 1	- 15 11

# TABLE III. MODEL DIMENSIONAL DATA (Concluded)

MODEL COMPONENT: NOZZLES - N90

GENERAL DESCRIPTION: CMS nozzle for MCR 500 configuration.

MODEL SCALE: 0.040

DRAWING NUMBER: Fig. 4. APS Interface to OMS Engine and Interconnect

DIMENSIONS:	FULL SCALE	MODEL SCALE
MACH NO.		
Length, in.  Gimbal Point to Exit Plane Throat to Exit Plane	56.0 56.0	2.240
Diameter, in. Exit (ID) Throat (ID)	43.088 5.812	1.7235 0.23248
Gimbal Point (Station), in.  Nozzle  X  Y  Z	1518. 88. 492.	60.72 3.520 19.680
Null Position, Degrees Nozzle Pitch Yaw	15°49' 6°30'	15°49' 6°30'

TABLE IV. MODEL 65-0 INSTRUMENTATION AND PATTERN SUMMARY

a. Base Heat Shield

PARAMETER	מעות	TYPE		INST	RUMENTA	TION :	PATTE	RNS
TARMETER	111		1	2	4	6	7	8
HT0100	Thin-Film	n Gauge	X	IM-n	Х	38.1	X	X
HTO101			x	х	Х	EEJ	X	X
HT0102			. х		х	1 422	X	X
HT0103			x	Х	Х	139	X	X
HT0104			X		х	TEA	X	X
HT0105			X	Х	х	881	X	X
нто106			X			561		
нто108			Х		х	193	X	X
HT0109	T X		X		х	- 50	X	X
HTO110			X	х	х	904	X	X
HTO111			Х	х	х	121	X	X
HT0112			X	х	Х	984	X	X
HT0113			X		Х	dgy	X	X
HT0115			X			135		
HT0116	X X		X	Pres	Х	500	X	X
HT0121	x x		Х			Ead		
HT0124	x x		X		х	401	X	X
HT0125	x x		X	х	Х	101	X	X
HT0131	\ \ \ \ \		X	X	Х	300	X	X

TABLE IV. MODEL 65-0 INSTRUMENTATION AND PATTERN SUMMARY (Continued)

a. Base Heat Shield (Continued)

	CITATO 22		INS	TRUMENT.	ATION :	PATTER	RNS
PARAMETER	TYPE	1	2	4	6	7	8
HT0132	Thin-Film Gauge	X	Х	X	00.	Х	X
HT0133		X	Х	Х	101	X	X
HT0134		X		X	300	Х	X
HT0135	x x	X	Х	X	103	X	X
HT0137		X		X	1.04	X	X
нто138	x x	X			105		
HT0139	The second second	X		X	901	X	X
HT0193	X X	X		Х	80.0	Х	X
HT0405		X	X	X	601	X	X
HT0406	x x	X	Х	Х	OLI	X	X
HT0431		X	X	Х	1111	X	X
HT0432		X	Х	Х	SII	X	X
HT0434		X	X	Х	EIII	X	X
HT0435	¥ x	X	Х	Х	SII	X	X
BP0002	Low Pressure	X	Х	Х	BIS	X	X
BP0003		X	Х	X	121	X	X
BP0004	X X	X	X	Х	45.1	X	X
BP0005	x x x	X	X	Х	₹8.3	X	X
BP0006	x x x	X	X	X	15.	X	X

TABLE IV. MODEL 65-0 INSTRUMENTATION AND PATTERN SUMMARY (Continued)

a. Base Heat Shield (Concluded)

PARAMETER	TYPE		INSTRUMENTATION PATTERNS							
TAIWEILK	111.6	1	2	4	6	7	8			
BP0007	Low Pressure	Х	х	X	18. ea	Х	Х			
BP0008	x x x	X	Х	Х	102	Х	Х			
BP0009	x x x	X	X	Х	130	Х	X			
BPOOLL	X X X X	X	Х	Х	Toe	Х	X			
BP0013	x z z	X	Х	Х	084	Х	X			
BP0015	x x z	X	Х	. х	210	Х	X			
BP0018		X	X	Х		Х	Х			
BP0020		X	х	х		Х	X			
						tang				
	I X X		IN M			T.B				
	x x x				35	Ma				
	X   X   X				85.					
	X Z Z Z				OUI					
	x x x				333					

TABLE IV. MODEL 65-0 INSTRUMENTATION AND PATTERN SUMMARY (Continued)

b. SSME Engine Mounted Heat Shields

PARAMETER	mv n	TYPE INSTRUMENTATION PAGE					
PARAMETER	TIPE	1	2	4	6	7	8
Engine #1	x x x	950	REME I		701		
HT0107	Thin-Film Gauge	Х	Х	X	891	X	X
HT0130	T X X	X	X	Х	800	X	X
HT0407	z i i z i	X	Х	Х	II	Х	X
HT0430		X	Х	Х	ELI	X	X
BP0012	Low Pressure	X	Х	Х	Х	X	X
Engine #2	x x x				Ex		
BP0016	Low Pressure	X	X	X	Х	Х	X
Engine #3							
HT0117	Thin Film Gauge	Х	Х	Х		X	X
HT0126		X	Х	Х		X	X
HT0136		X	Х	Х		X	X
HT0140		X	Х	Х		X	X
нто436	•	Х	Х	X		X	X

TABLE IV. MODEL 65-0 INSTRUMENTATION AND PATTERN SUMMARY (Continued)

c. Center Base Heat Shield Flow Diverter

DADAMETER	(IIV)		INST	RUMENT.	ATION F	ATTER	NS
PARAMETER	TYPE	1	2	4	6	7	8
нто 400	Thin-Film Gauge	gueb	IN-E	Х	001	TH	
нто403				Х		28.	
HTO404	x x x			Х	9034	98	
HT0410	x x x			Х	501	TR	
	The latest				308	TA	
	z z z				809.4	113	
	x x x				7054	13	
	X   X     X				8094	DH.	
	x x				1000	38	
	x x				COS A	28	
	x la						
	x   x   x				0.0	24	
	x x				rs d	23	
	x   x   x				12 1	23	
	x x				\$81.2		

TABLE IV. MCDEL 65-0 INSTRUMENTATION AND PATTERN SUMMARY (Continued)

d. SSME Drain Line Nozzle (Hatband)

HT4200		TOMORTOWER .		INS	TRUMENT.	ATION	PATTER	RNS
HT4201	PARAMETER	TYPE	1	2	4	6	7	8
HT4202	HT4200	Thin-Film Gauge	x	Х	x	004	Х	
HT4203       X       X       X       X         HT4205       X       X       X       X         HT4206       X       X       X       X         HT4207       X       X       X       X         HT4208       X       X       X       X         HT4209       X       X       X       X         HT4210       X       X       X       X         HT4211       X       X       X       X         HT4220       X       X       X       X         HT4221       X       X       X       X         HT4231       X       X       X       X	HT4201		X	X	X	E04	Х	
HT4205 HT4206 HT4207 HT4208 HT4209 HT4210 HT4210 HT4220 HT4220 HT4221 HT4231  X X X X X X X X X X X X X X X X X X	HT4202	x	Х	Х	X	404	Х	
HT4206	HT4203	x less less less less less less less les	Х	X	X	014	Х	
HT4207       X       X       X       X         HT4208       X       X       X       X         HT4209       X       X       X       X         HT4210       X       X       X       X         HT4211       X       X       X       X         HT4220       X       X       X       X         HT4221       X       X       X       X         HT4231       X       X       X       X	HT4205		X					
HT4208	HT4206		X	X	. x		х	
HT4209	HT4207		X	Х	Х		X	
HT4210	HT4208		X	X	Х		Х	
HT4211	HT4209		X	Х	X		Х	
HT4220	HT4210		Х	Х	Х		Х	
HT4221	HT4211		X	Х	X		Х	
HT4231 X X X X	HT4220		X	Х	x		х	
	HT4221		X	X	X		Х	
HT4282 X X X X	HT4231		х	X	x		X	
	HT4282	+	X	X	X		X	

TABLE IV. MODEL 65-0 INSTRUMENTATION AND PATTERN SUMMARY (Continued)

e. SSME Firing Nozzle No. 1 (Hatband)

DADAMEND	WALKSTI.	90	INST	RUMENTA	TION H	PATTERI	ERNS		
PARAMETER	TYPE	1	2	4	6	7	8		
HT1201	Thin-Film Gauge		Х			73			
HT1202	x x	х	Х	Х	Earl	х	X		
HT1203	x 2	Х	Х	Х		X	X		
HT1204		Х	X	Х	809	X	X		
HT1206		Х	Х	X		Х	X		
HT1208	X X		Х		0.00	TH			
HT1210	x   x	х	Х	х	10	Х	X		
HT1211		Х			914	TH			
HT1212		Х	Х	Х		X	X		
HT1213			X		283	THE .			
HT1221		X	Х	X	333	X	X		
HT1222		х	Х	X		X	X		
HT1223			x		720				
HT1251			X		88				
HT1252		х	X	Х		X	X		
HT1253		Х	X	Х		X	X		
HT1271			X						
HT1272		Х	X	Х		Х	Х		
HT1273		Х	X	Х		X	Х		
HT1281	X X		х						
HT1282		х	х	х	-0	Х	Х		
HT1283		Х	X	X		X	X		

TABLE IV. MCDEL 65-0 INSTRUMENTATION AND PATTERN SUMMARY (Continued)

f. SSME Firing Nozzle No. 3 (Hatband)

MAG ROTTE	MIRTERI		INST	RUMENT	ATION I	PATTER	NS
PARAMETER	TYPE	1	2	4	6	7	8
HT3201	Thin-Film Gauge	Х	Х	Х			X
HT3202		X			808		
HT3203	7 X	X	X	Х	908		Х
HT3204	x x	X	Х	Х	803	e i	X
HT3205		X			dog		
нт3206		X	Х	Х			Х
HT3208	X X	X	X	Х			X
HT3210	X	X	Х	. X	809		X
HT3211	z z	X	Х	Х	ors		2
HT3212	x	X	Х	Х	1118	W.	2
HT3213	c x x		Х		318		
HT3221		X	Х	Х	1.15		2
HT3222	c x x	X	X	X	138	C.H.	3
HT3223	v x x		Х		888	IT H	
HT3251	X		Х		£85		
HT3252	1 2 2	X	X	Х			2
HT3253	x x	X	Х	X	252		2
HT3271	T X		Х		E83		
HT3272		X	Х	Х			7
HT3273	X X X	X	Х	X			7
HT3281	X X X		Х				
HT3282	X	X	X	Х		LAPR	7
HT3283	X X X	x	х	Х	50		3

TABLE IV. MODEL 65-0 INSTRUMENTATION AND PATTERN SUMMARY (Continued)
g. SSME Smooth Wall Nozzle

PARAMETER	TYPE		INST	RUMENT	ATION	PATTE	RNS
TAIMILLER	TIFE	1	2	4	6	7	8
HT0200	Thin-Film Gauge		IB-a		487	X	X
HT0201						X	X
HT0202	X X				OTA	Х	X
HT0204						X	X
HT0205						Х	X
HT0206	X X				n ple	X	X
HT0207	x X				680	X	X
HT0208						X	X
HT0209						X	X
HT0210						Х	Х
HT0211	<b>†</b>					X	X

TABLE IV. MODEL 65-0 INSTRUMENTATION AND PATTERN SUMMARY (Continued)

h. Body Flap

74744	DESTRUCTION		INS	PRUMENT.	ATION	PATTE	RNS
PARAMETER	TYPE	1	2	4	6	7	{
нто164	Thin-Film Gauge	Х	X	Х	025	Х	X
нто168		Х	Х	Х		X	X
HT0170		Х	X	Х	505	X	x
HT0174	<b>*</b>	X					
					205	TH.	
BP0047	Low Pressure	X	X	. X	hus	X	X
BP0055	1	x	X	Х	108	X	X
					608		
					Pac	TH.	

TABLE IV. MODEL 65-0 INSTRUMENTATION AND PATTERN SUMMARY (Continued)

i. Left OMS/RCS Pod

DADAMERED	mvn-		INST	RUMENT	ATION	PATTER	NS
PARAMETER	TYPE	1	2	4	6	7	8
нто146	Thin-Film Gauge	X	915 W	4	820	96	
HT0150	x x	x			E400		
HT0151	X X	X	X	Х	3400	X	X
HT0152		X	X	Х		X	X
HT0160	•	X	Х	X		X	X

TABLE IV. MODEL 65-0 INSTRUMENTATION AND PATTERN SUMMARY (Continued)
j. Right CMS/RCS Pod

71711	STEP SEED		INST	RUMENT	ATION I	PATTER	NS
PARAMETER	TYPE	1	2	4	6	7	8
BP0038	Low Pressure	X	X	Х	9010	Х	Х
BP0043	z l	X	X	Х	1150-	Х	Х
BP0046	1 x	X	Х	Х	NEE	X	X
	z x				nisa		
	x x				neo		
				•			
		-					

TABLE IV. MODEL 65-0 INSTRUMENTATION AND PATTERN SUMMARY (Continued)

k. Vertical Tail

24244	DMM1881		INST	RUMENTA	ATION E	ATTER	NS
PARAMETER	TYPE	1	2	4	6	7	8
HT0178	Thin-Film Gauge	Х	Х	Х		Х	Х
HT0179	п п п	Х	х	Х	013	Х	Х
						GH.	
					530	THE STATE OF	
					2.20		
					480	51	
					380	TE	
					280		
					100		
					E30		
					STO		

TABLE IV. MODEL 65-0 INSTRUMENTATION AND PATTERN SUMMARY (Continued)

1. Tile Gap Base Heat Shield

7171777	CORPORT I		INST	RUMENTA	ATION E	ATTERI	IS
PARAMETER	TYPE	1	2	4	ć	7	{
HT5011	Thin-Gilm Gauge				Х		
HT5012				1000	х		
HT5013					Х		
HT5021					Х		
HT5022					Х		
HT5023					Х		
HT5031					Х		
HT5032					Х		
HT5033					Х		
HT5041					Х		
HT5042					Х		
нт5043					Х		
HT5051					Х		
HT5052					Х		
нт5053					Х		
нт5061					Х		
нт5062					Х		
нт5063					Х		
HT5071					Х		
HT5072		-			Х		

TABLE IV. MCDEL 65-0 INSTRUMENTATION AND PATTERN SUMMARY (Continued)

1. Tile Gap Base Heat Shield (Continued)

PARAMETER	TYPE		INST	RUMENT	ATION	PATTERI	NS
PARAMETER	TIPE	1	2	4	6	7	8
HT5073	Thin-Film Gauge	ашей		4.60	Х		
HT5081					Х		
HT5082					х		
HT5091					Х		
HT5101					Х		
HT5111					х		
HT5112					х		
HT5121					х		
HT5122					X	4	
HT5131					Х		
HT5132					X		
HT5141					х		
HT5142					х		
HT5151					x		
HT5152					x		
HT5161					X		
HT5162					Х		
HT5171					x	The state of the s	
HT5172					X	TH	
HT5181					X		

TABLE IV. MODEL 65-0 INSTRUMENTATION AND PATTERN SUMMARY (Continued)

1. Tile Gap Base Heat Shield (Continued)

			INST	RUMENT	ATION E	PATTERN	S
PARAMETER	TYPE	1	2	14	6	7	8
HT5182	Thin-Film Gauge		277	2	Х	28	
HT5211					Х		
HT5212					Х	28	
HT5213					Х		
HT5221		Approximate of the control of the co			Х		
HT5222					Х		
HT5223					Х		
HT5231					Х		
HT5232					Х		
HT5233					Х		
HT5241					Х		
HT5242		Annual Control of Cont			Х		
HT5243					X		
HT5251					X		
HT5252					Х		
нт5253					Х	MA A	
HT5261				The state of the s	Χ		
HT5262					X		
нт5263					Х		

TABLE IV. MODEL 65-0 INSTRUMENTATION AND PATTERN SUMMARY (Continued)

1. Tile Gap Base Heat Shield (Concluded)

DA DANGETED	3000000		INST	RUMENT	ATION E	ATTER	NS
PARAMETER	TYPE	1	2	4	6	7	8
HT5271	Thin-Film Gauge	SUIDO.	afitta		Х	SEEK .	
HT5272	1				X		
HT5273					Х		
HT5281					х		
HT5282					Х		
HT5291					х		
нт5292					Х	211	
HT5301					$_{\rm x}$	177	
HT5302					x	11.5	
HT5311					x		
HT5312					X		
HT5321					X		
HT5322							
HT5323					X		
					X		
HT5331					X		
HT5332					X		
HT5333					X		
HT5341					Х		
HT5342					Х		
HT5351					х		
HT5352					X		

TABLE IV. MCDEL 65-0 INSTRUMENTATION AND PATTERN SUMMARY (Concluded)

m. Tile Gap Body Flap

DADAMENTO	THE T		INST	TRUMENT	ATION	PATTEI	NS
PARAMETER	TYPE	1	2	4	6	7	8
нт6761	Thin-Film Gauge		al 192-		х		
HT6762		Tento - you are not you have nown have nown have not you have not you have not you have not you			х	TR	
нт6763					Х		
нт6771					Х		
нт6772					Х		
HT6781					Х		
HT6782					Х		
нт6791	<b>*</b>				Х		
					ш		
					100		
					388		
					828		
					188		
					388		
					488		

# TABLE V. TEST SETUP SHEETS

# · OH-79 ENTRY CONFIGURATION

YATHE			DES	CRIPTOR				13711	ENTRY:
1	N	F	A	6	0	1	1,4,6,8	В	. 08
NOTES:	120K 150K	1 4					VIDAR ga		tern
	180K 240K	6					1	F	

BETA
-0.7
-4.2
+2.8

ADDITIONAL I	NSTRUCTIONS:	101	8	хээлэ. 11	
			0.1 =		

		1	
INITIATOR: W. F.	Braddock	DATE:	7/26/78

# TABLE V. TEST SETUP SHEETS (Concluded) OH-79 TEST RUN CONDITIONS

OBJECTIVE:	DESCRIPTOR	ENTRY:
	PARALLEL YAW, PITCH GIMBAL	08

Γ	RUN N	LIMBER	08-1	08-3	08-2	08-4
	DESCR		1NFA6011B	1NFA6018B	1NFA6016B	1NFA6014B
	GO <sub>2</sub>	BEFORE	2770	2780	2770	2780
PR	(PSI)	AFTER	2655	2680	2665	2680
ES	GH <sub>2</sub>	BEFORE	2625	2625	2625	2625
SU	(PSI)	AFTER	2565	2565	2565	2565
R	GN <sub>2</sub>	OPEN	2510	2510	2510	2510
ES	(PSI)	CLOSE	2980 2980 2980		2980	2980
		HOLD	1310	1310	1310	1310
	COMBUS	TOR (PSI)	1500	1500	1500	1500
	SIMULA	TED (KFT)	120	. 240	180	150
A	PCH	REQ'D	1.83	1.27 x 10 <sup>-2</sup>	1.73 x 10 <sup>-1</sup>	5.44 x 10 <sup>-1</sup>
T	(TORR)	ACTUAL	1.84	1.38 x 10 <sup>-2</sup>	1.725 x 10-1	5.47 x 10 <sup>-1</sup>
T I M E	С	LOCK	09:49:24	11:59:48	10:59	12:39:50
M E	. IR	IG-B	207 days 9:49:25:355	207 days 11:59:21:824	207 days 10:59:28:596	207 days 12:39:56:244
	BASE TE	MPS (°F)	76.0 77.2 76.1	81.2 85.6 81.3	79.4 81.1	84.6 84.7

REMARKS:						
	Tl	=	1.0			
	T2	=	3.5			
	T <sub>3</sub>	=	1.8			
	$T_S$	=	2.1			

1							
1	INITIATOR:	P.	T	Lemoine	DATE .	7/26/78	1
į			т.	Demorite	DAIL.	1/20/10	

#### TABLE VI. TEST DESCRIPTOR DEFINITION

## FIRST CHARACTER: Instrumentation Configuration

- 1 = Basic cold base
- 2 = Basic cold base with nozzle clocking
- 4 = Basic cold base with flow block device
- 6 = Tile gap heat shield and body flap
- 7 = Smooth wall nozzle #2, #3 hatband in #1 position
- 8 = Smooth wall nozzle #2, drainline in #1 position

## SECOND CHARACTER: Body Flap Configuration

N = Body flap undeflected  $(\delta_{BF} = 0^{\circ})$ 

### THIRD CHARACTER: SSME Chamber Pressure

F = 1500 psi

## FOURTH CHARACTER: SSME Operating Pattern

- A = All operating, SSME hatband nozzles @  $\phi = 0^{\circ}$
- B = All operating, SSME hatband nozzles @  $\phi$  = 30°
- C = All operating, SSME hatband nozzles @  $\phi = 60^{\circ}$ 
  - D = All operating, #1 ( $\phi$  = 240°), #2 ( $\phi$  = 120°), #3 ( $\phi$  = 60°)
  - E = All operating, #1 ( $\phi$  = 270°), #2 ( $\phi$  = 150°), #3 ( $\phi$  = 90°)

# FIFTH CHARACTER: SSME Gimbal Pattern

- O = Pitch null, parallel burn
- 1 = -2° pitch, parallel burn
- $2 = +2^{\circ}$  pitch, parallel burn
- 3 = +5° pitch, parallel burn
- $4 = -5^{\circ}$  pitch, parallel burn

### TABLE VI. TEST DESCRIPTOR DEFINITION (Continued)

### FIFTH CHARACTER: SSME Gimbal Pattern (Continued)

5 = (-5, +0.7), (-5, -2.8), (-5, +4.2)

6 = (-5, -0.7), (-5, -4.2), (-5, +2.8)

7 = (-2, +0.7), (-2, -2.8), (-2, +4.2)

8 = (-2, -0.7), (-2, -4.2), (-2, +2.8)

9 = (0, 0), (0, 0), (0, 0) benign gimbal (actuator null)

A = (+5, 0), (+5, 0), (+5, 0) benign gimbal

B = (-5, 0), (-5, 0), (-5, 0) benign gimbal

C = (0, 0), (0, +5), (0, -5) benign gimbal (increased yaw)

D = (+5, 0), (+5, +5), (+5, -5) benign gimbal (precant)

E = (-5, 0), (-5, +5), (-5, -5) benign gimbal (precant)

F = (0, +1), (+10.77, -2.23), (-10.77, -2.23) + roll gimbal

G = (0, -1), (-10.77, +2.23), (+10.77, +2.23) - roll gimbal

It is again noted that F and G gimbal angles are measured from the parallel yaw position; all others are from actuator null (lower SSME's at 3.5° outboard yaw).

# SIXTH CHARACTER: CMS Engine Chamber Pressure

O = Zero psi (off)

# SEVENTH CHARACTER: OMS Gimbal Angles

1 = Stowed (non-firing) position  $(+6^{\circ}, \pm 7^{\circ})$ 

# TABLE VI. TEST DESCRIPTOR DEFINITION (Concluded)

# EIGHTH CHARACTER: Simulated Pressure Altitude

1 = 120K feet

4 = 150K feet

6 = 180K feet

8 = 240K feet

## NINTH CHARACTER: Flow Diverter

A = Instrumented

B = Off

TABLE VII. INSTRUMENTATION PATTERNS

	IRIG	77	4	†	7	77	4
CHANNELS	EVENT	7	7	7	7	3 1 1 <u>1 1 1 1 1 1 1 1 1 1 1 1 1 1 1 1 1</u>	L
VIDAR DATA ACQUISITION CHANNELS	HIGH-RANGE PCB	5	5	5	5	5	5
VIDAR DATA	LOW-RANGE PCB	20	20	20	a	20	50
-	TFG	90 0r 91	96	46	88	98	88
	DESCRIPTION	Parallel Yaw and Benign Gimbal Configurations	SSME Nozzle Clocking Configurations	Flow Diverter Configurations	Tile Gap Base Heat Shield and Body Flap Configuration	Roll Gimbal Configuration	Roll Gimbal Configuration
CHAMBER	CHAMBER ENTRIES USED 2 - 16		23 - 28	17, 19, 20	29 - 31	22	21
vacueronen A cr	PATTERN NO.	ı	2	† 18	9	L	- ∞

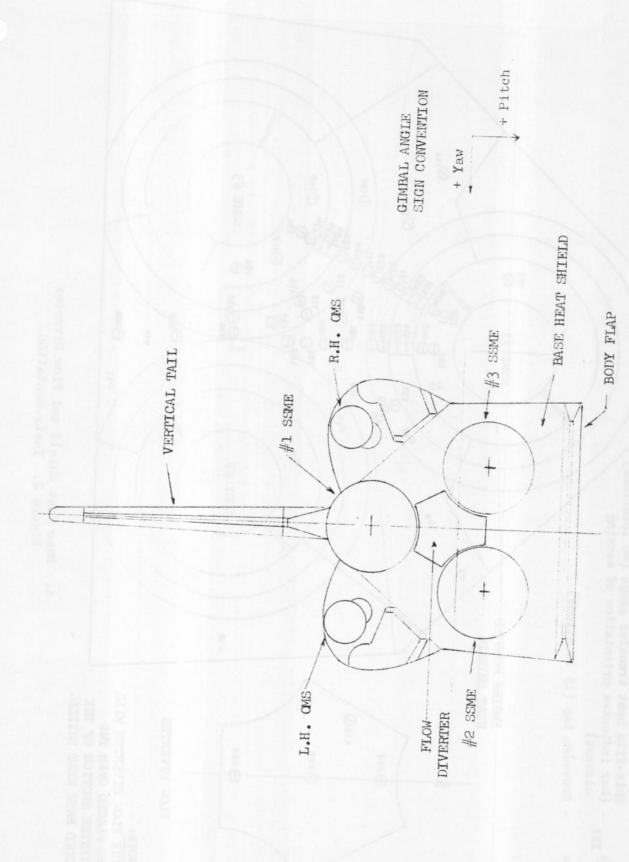
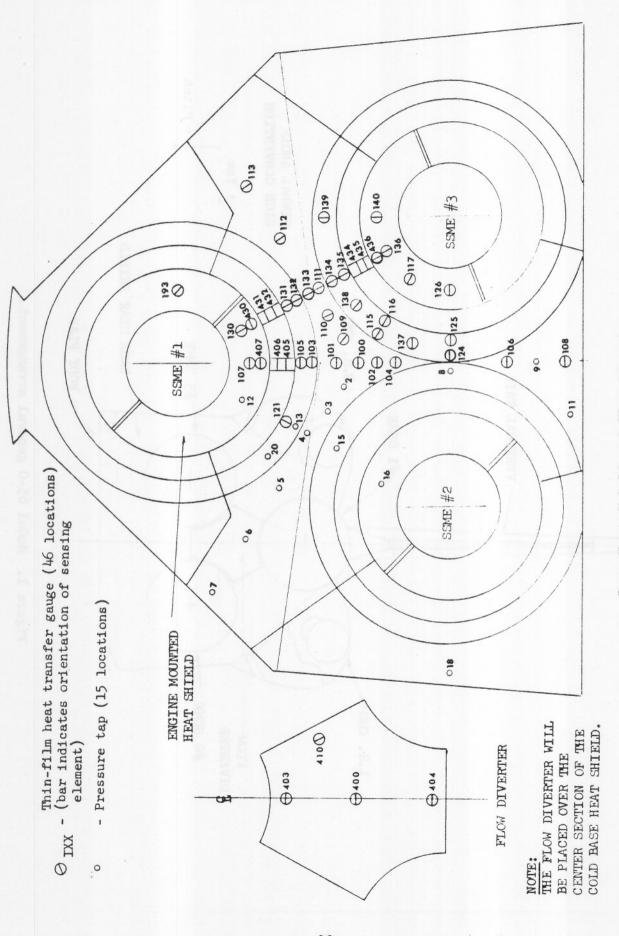
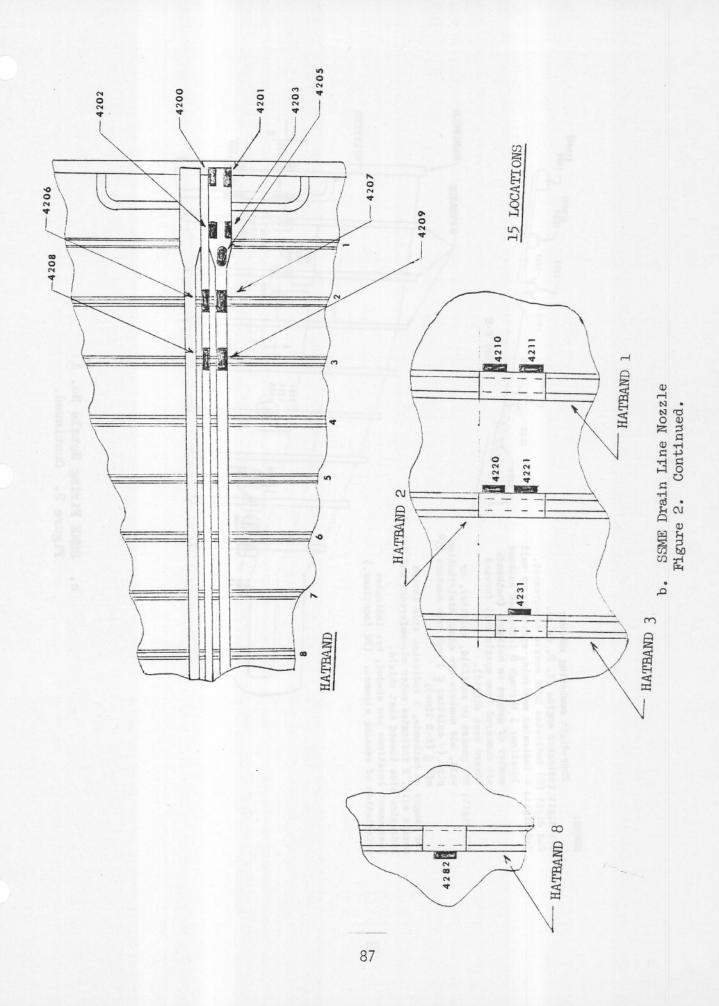
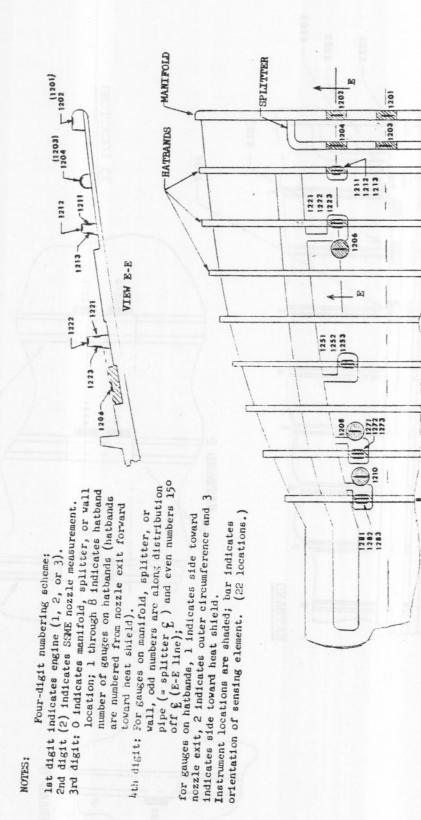


Figure 1. Model 65-0 general arrangement.

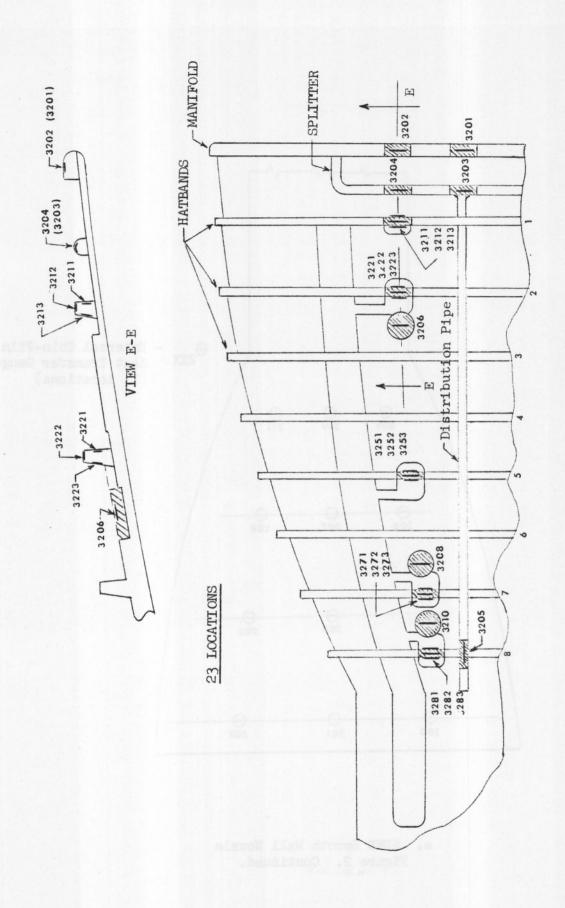


a. Base Heat Shield and Flow Diverter Figure 2. Instrumentation.

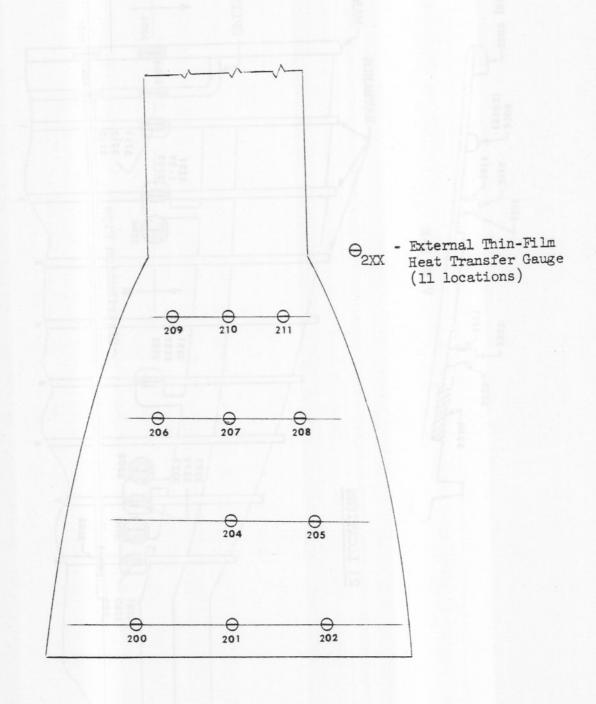




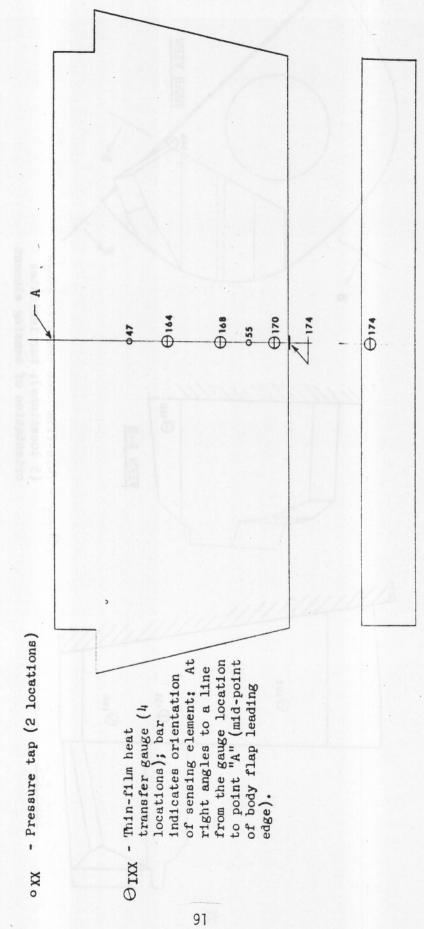
c. SSME Firing Nozzle No. 1 Figure 2. Continued.



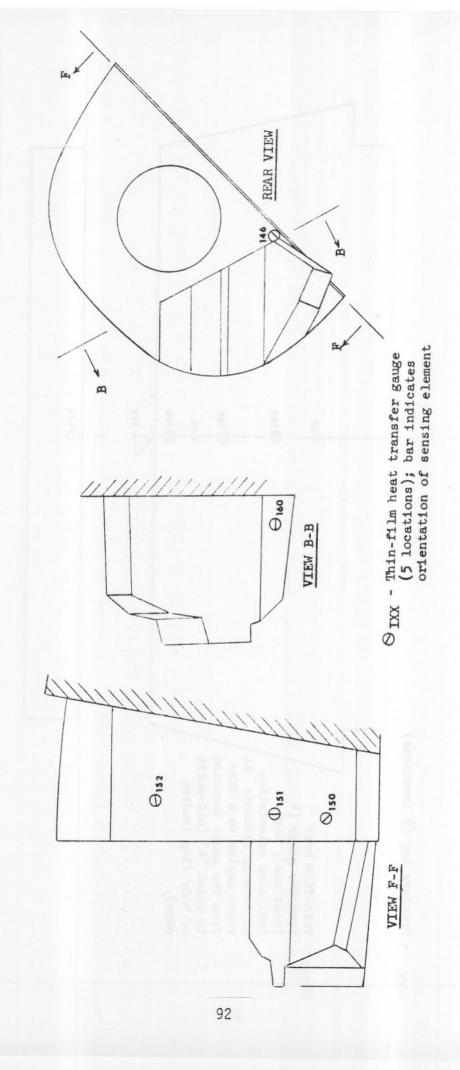
d. SSME Firing Nozzle No. 3 Figure 2. Continued.



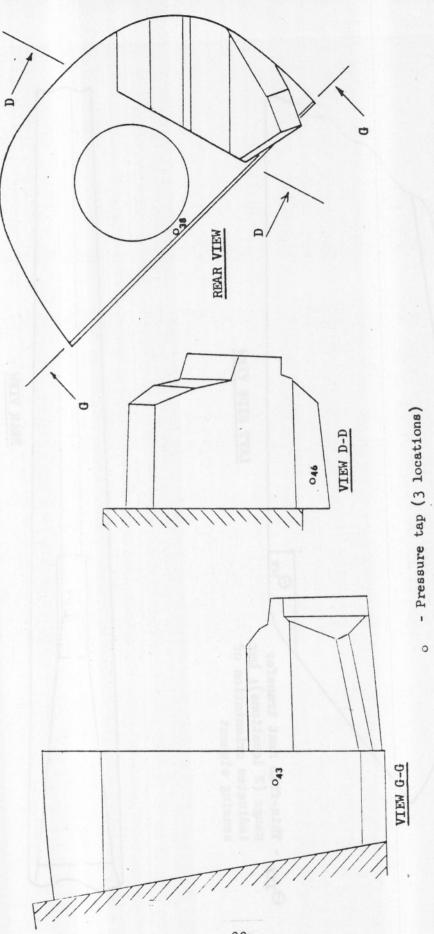
e. SSME Smooth Wall Nozzle Figure 2. Continued.



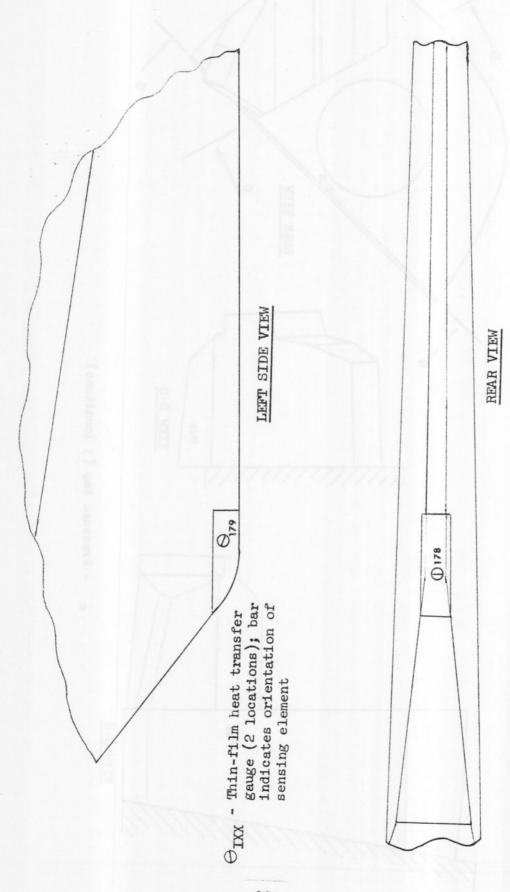
f. Body Flap Figure 2. Continued.



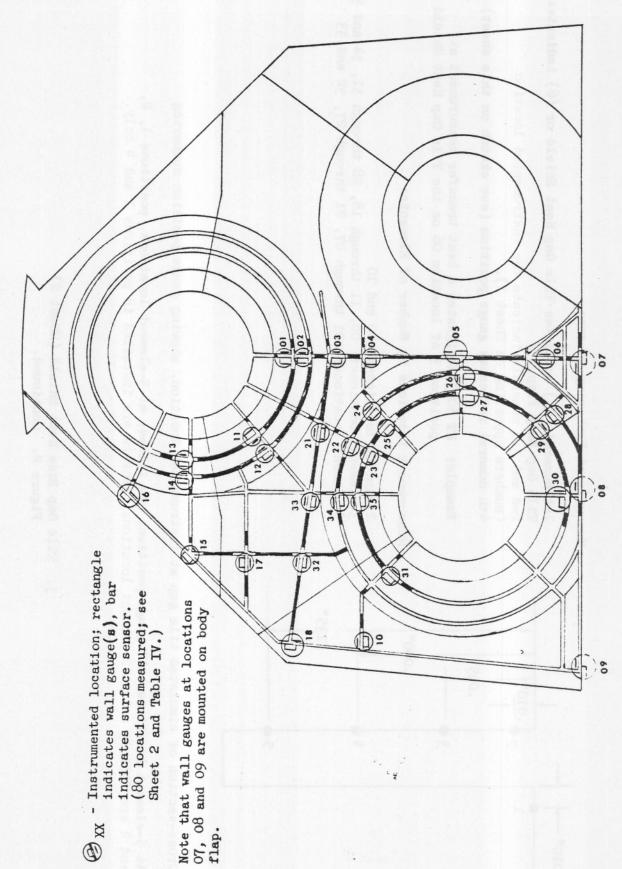
g. Left CMS/RCS Pod Figure 2. Continued.



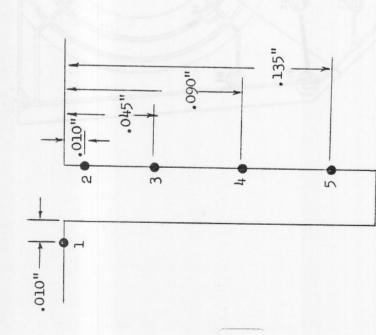
h. Right OMS/RCS Pod Figure 2. Continued.



i. Vertical Tail Figure 2. Continued.



Tile Gap Base Heat Shield (Sheet 1)
 Figure 2. Continued.



Measurement Numbering Scheme:

lst numeral (5) indicates Tile Gap Heat Shield or (6) indicates Tile Gap Body Flap.

2nd and 3rd numerals indicate the instrumented location (numbers appearing on Sheet 1). 4th numeral indicates gauge position (see sketch on this sheet)

Example: HT 5063 designates a heat transfer measurement at position 3 of location 06 on the Tile Gap Heat Shield

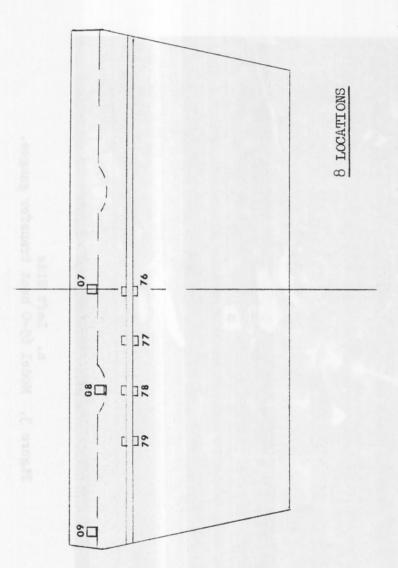
Measurement Locations by Number of Elements:

09 and 10 08, 11 through 18, 28 through 31, 34 and 35 01 through 07, 21 through 27, 32 and 33 2-element locations; 5-element locations: 3-element locations:

Cross-section of simulated tile gap at instrumented location, showing gauge position numbering

At 5-element locations, all gauge positions are filled; at 3-element locations, positions 1, 2, and 4 are filled; and at 2-element locations, sensors are installed in positions 1 and 4 only.

Tile Gap Base Heat Shield (Sheet 2)
 Figure 2. Continued.

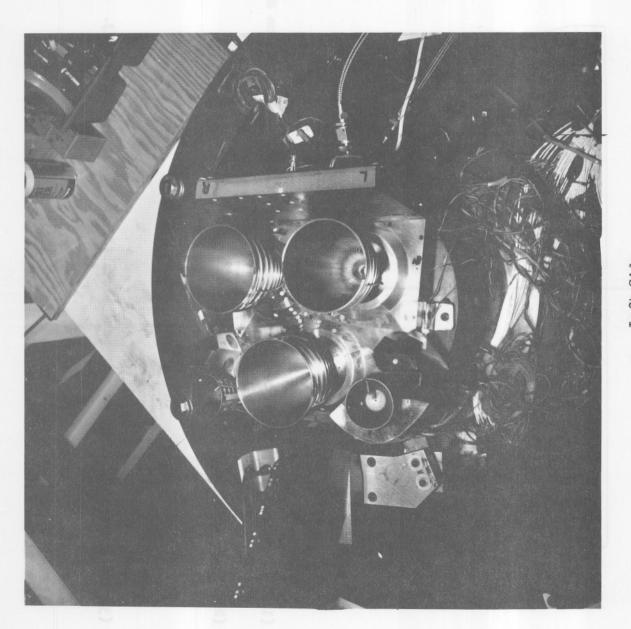


Wall gauges for base heat shield locations 07, 08 and 09 are shown on Sheet 1 of Figure 2j. (1) Notes:

No. of Sensors	r w w a
Gauge Locations	77 78 79
(2)	

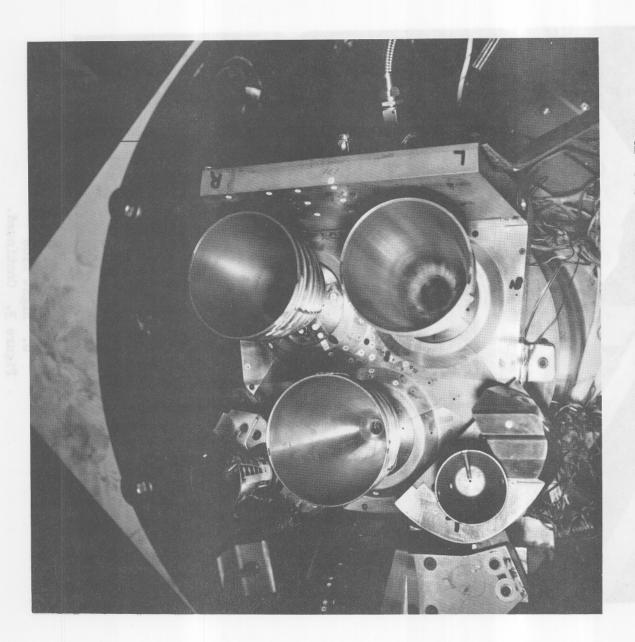
(3) For sensor placement at each gauge location see Sheet 2 of Figure 2j.

k. Tile Gap Body Flap Figure 2. Concluded.

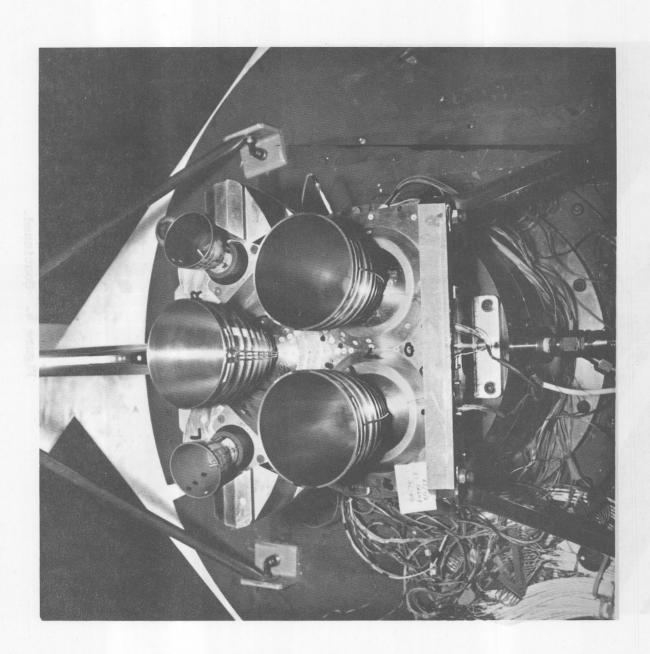


a. Left Side Figure 3. Model 65-0 heat transfer gauges.

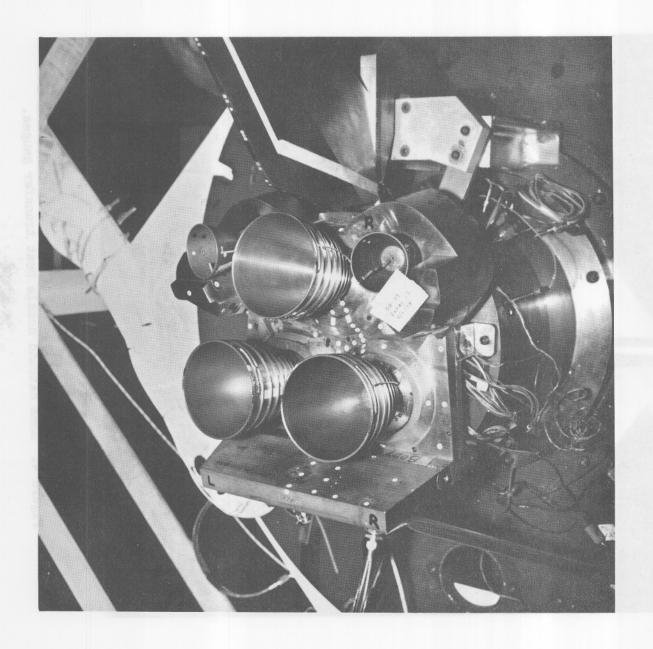
b. Right Side Figure 3. Continued.



c. Center Base Heat Shield and Body Flap Flgure 3. Concluded.



a. #1 SSME Position Figure 4. SSME hatband nozzle heat transfer gauges.



b. #2 SSME Position Figure 4. Continued.

c. #3 SSME Position Figure 4. Concluded.

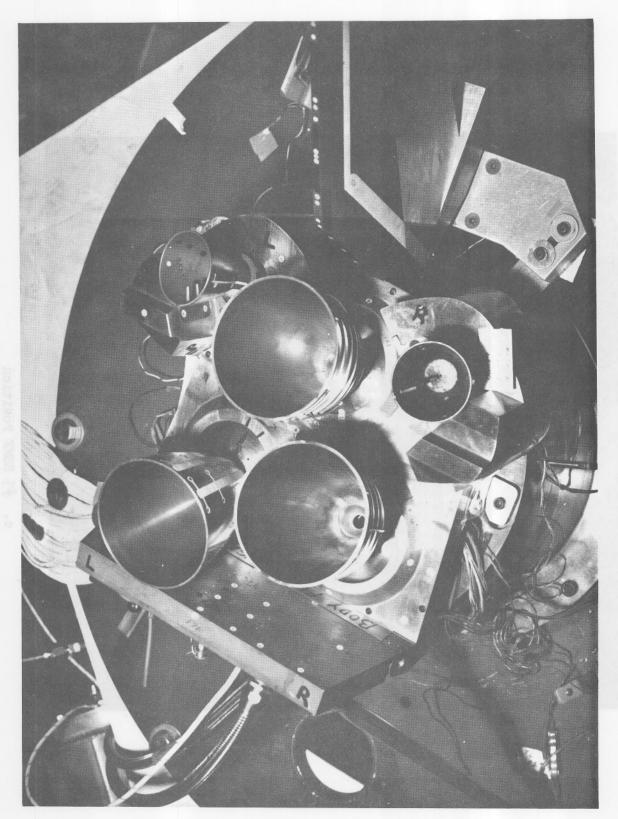
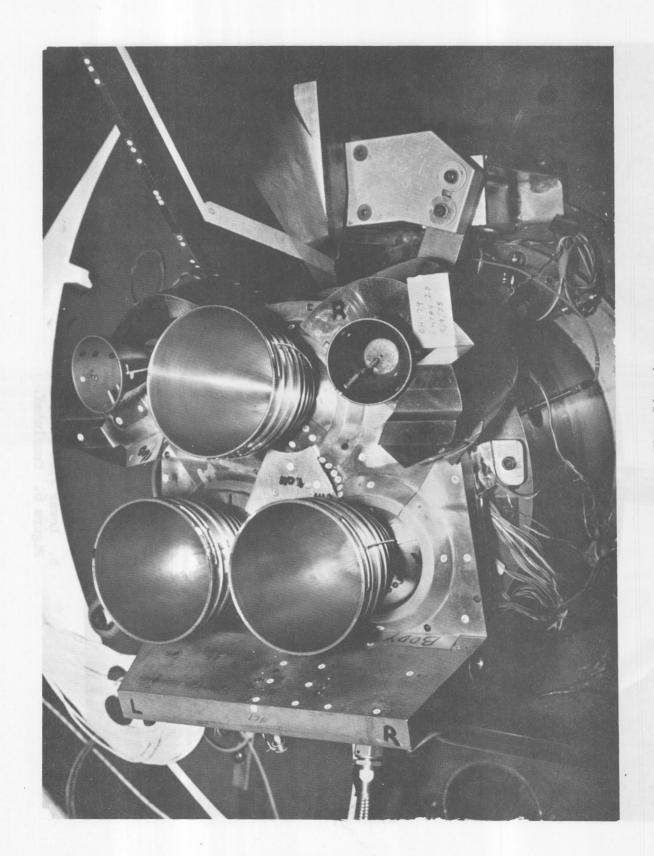
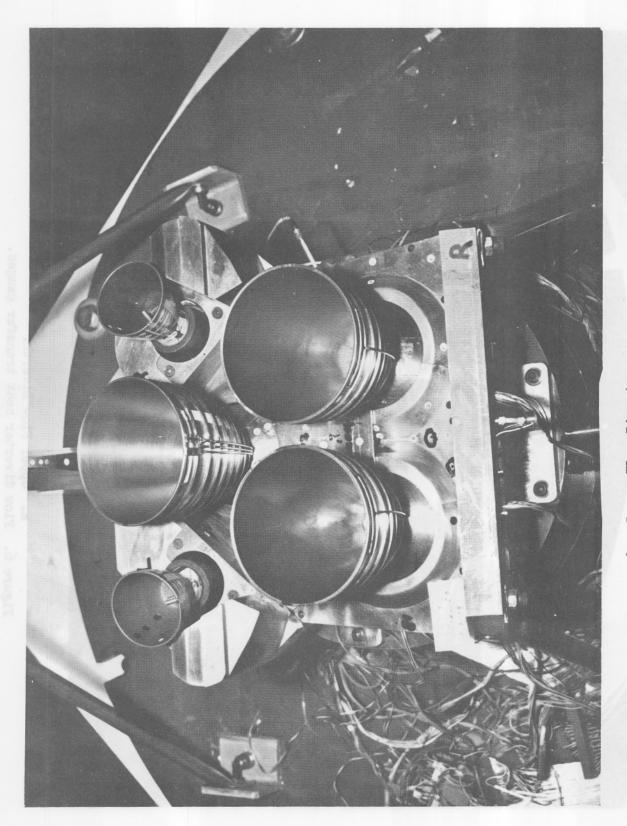


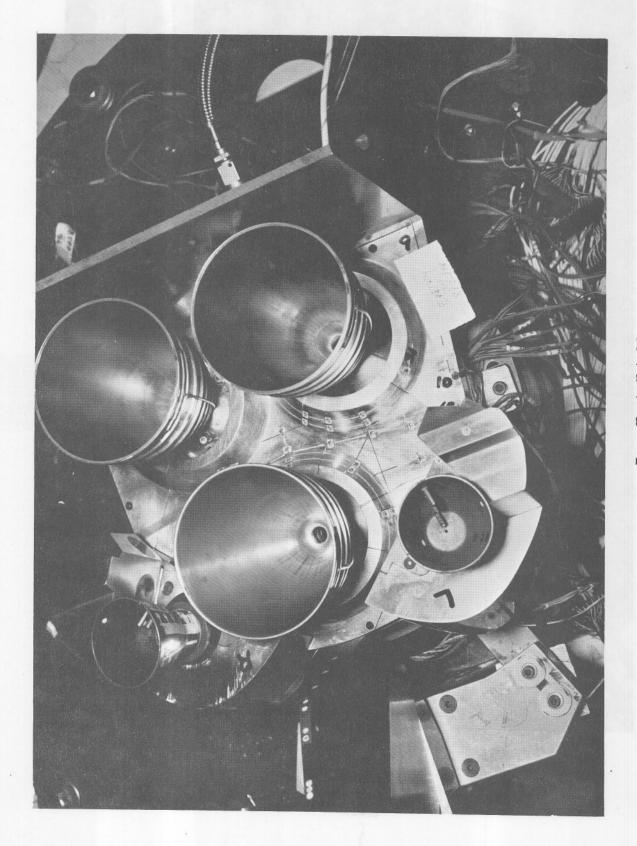
Figure 5. SSME smooth wall nozzle heat transfer gauges.



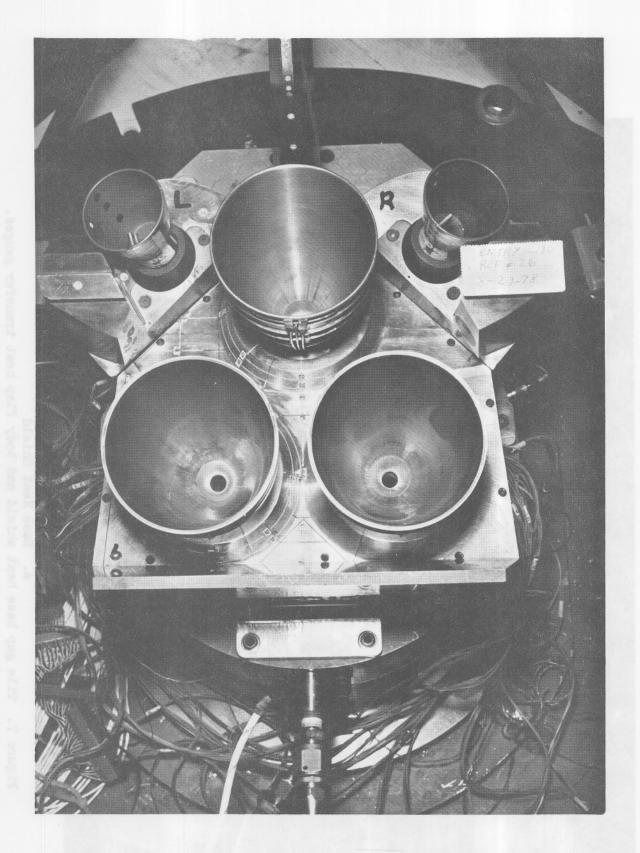
a. Upper Flow Diverter Figure 6. Flow diverter heat transfer gauges.



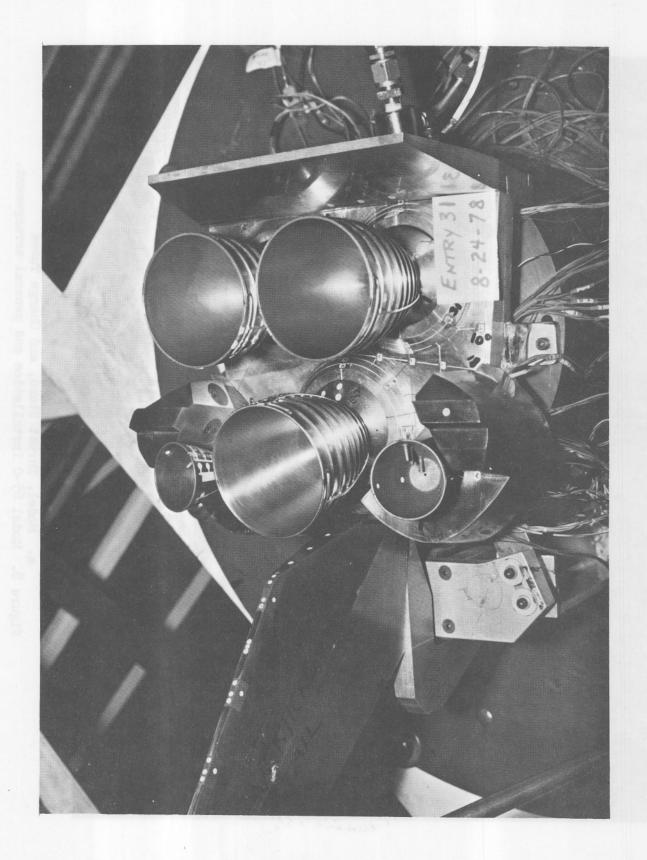
b. Lower Flow Diverter Figure 6. Concluded.

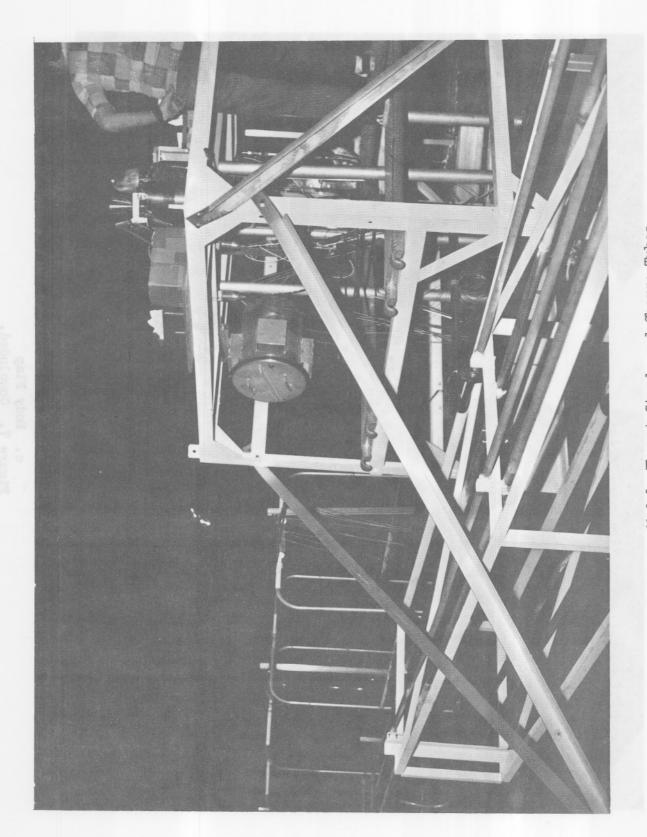


a. Base Heat Shield Figure 7. Tile gap base heat shield and body flap heat transfer gauges.

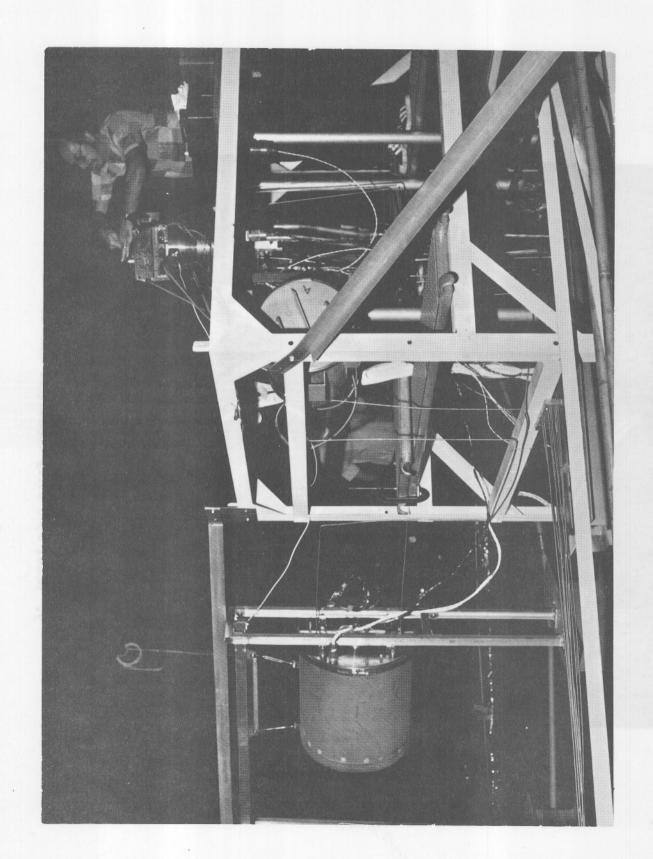


b. Base Heat Shield Figure 7. Continued.





a. Model, Thrust Stand, and Charge Tubes Figure 8. Model 65-0 installation and general arrangement.



b. Model, Thrust Stand, and Pressurized Containers Figure 8. Concluded.



9. Model 65-0 strip connectors and wire bundles.



Figure 10. Gas line arrangement inside Chamber A.

Figure 11. Gas control panels.

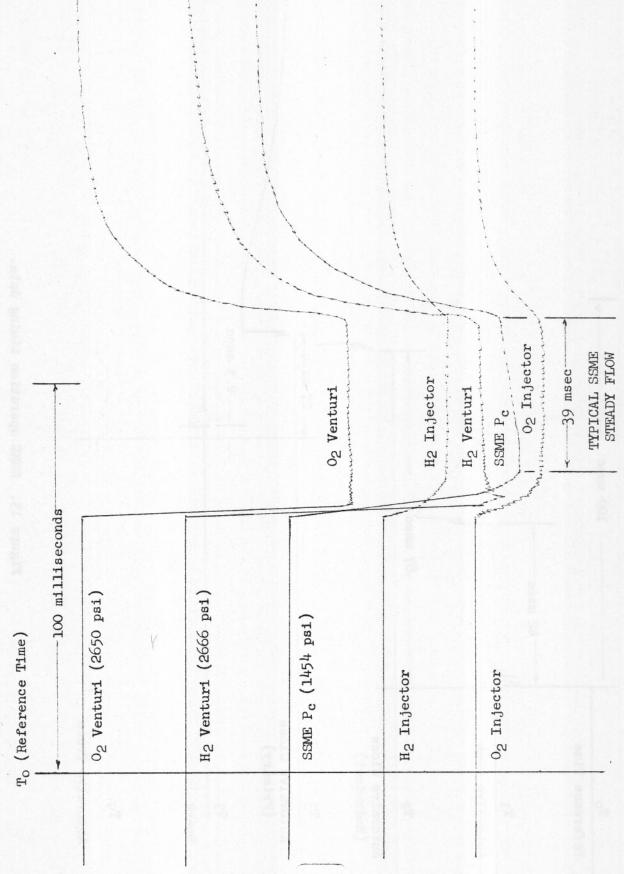


Figure 12. SSME operation pressure data.

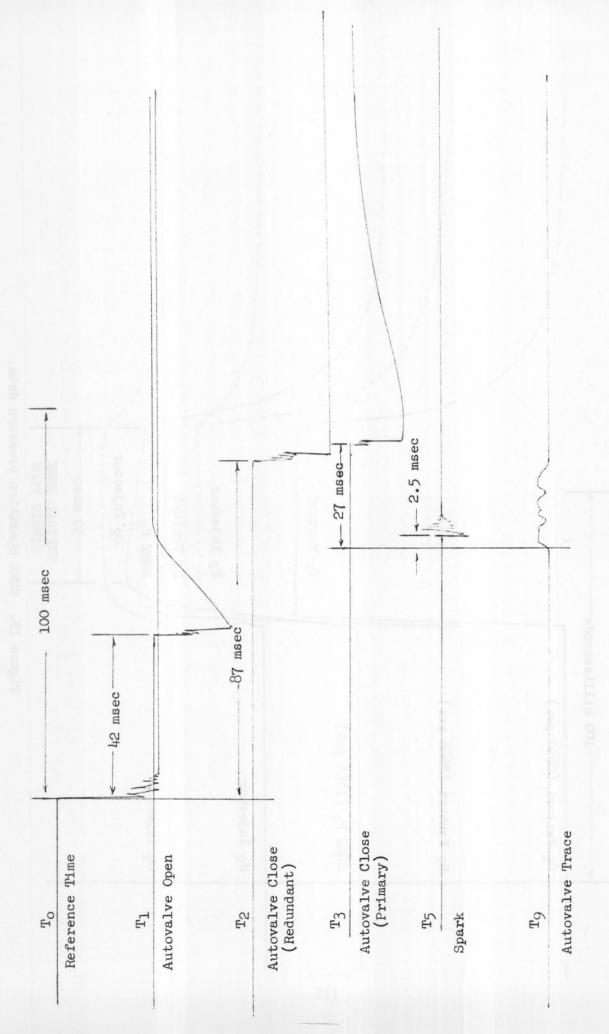
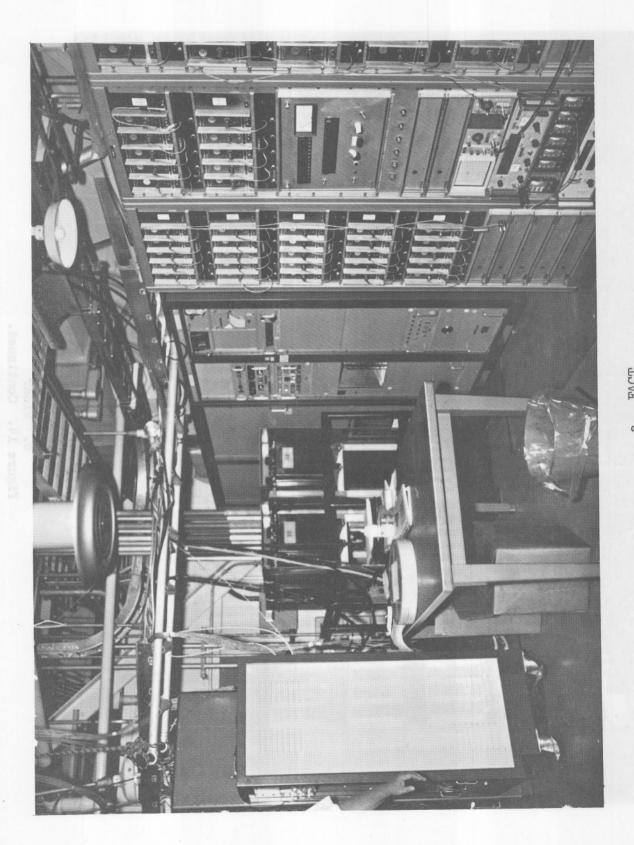
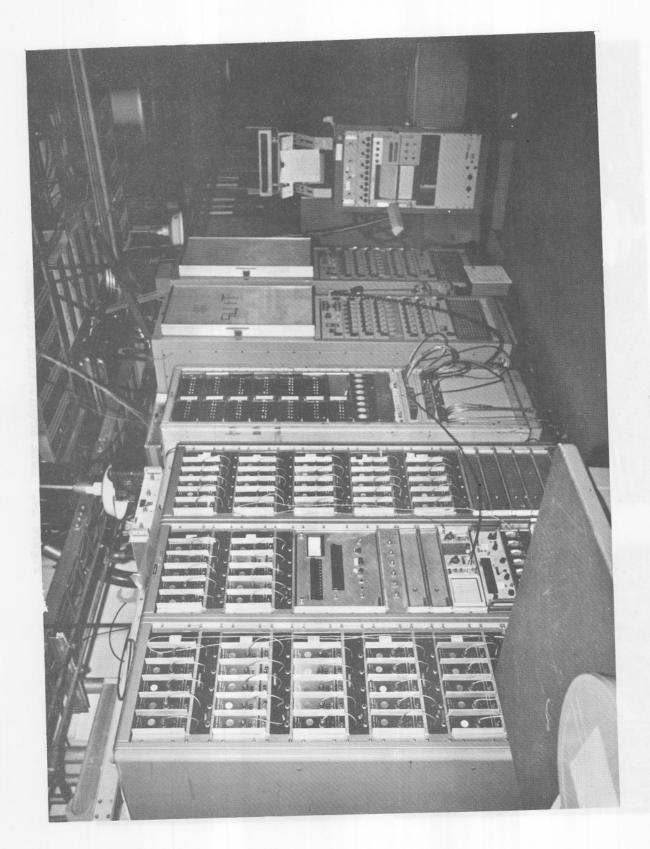


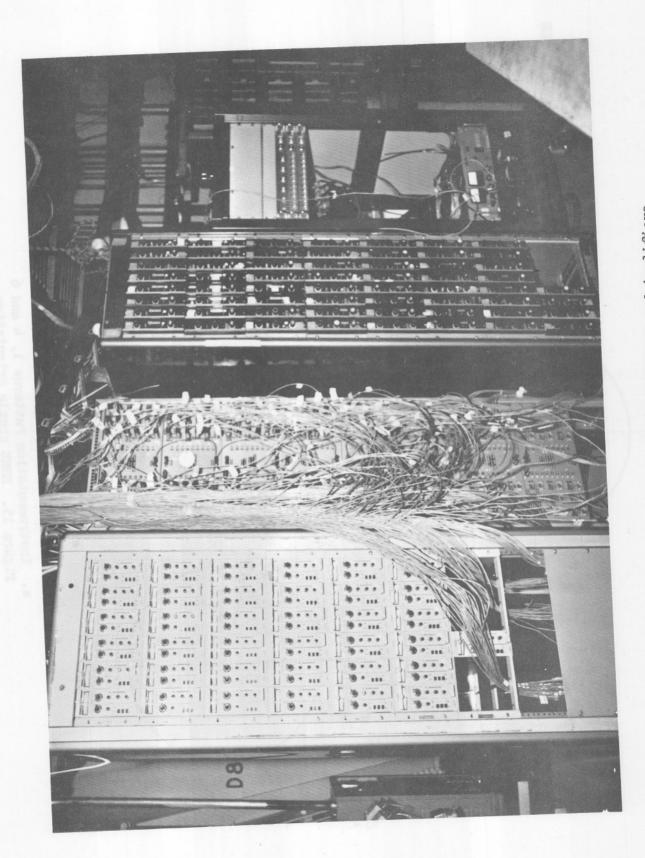
Figure 13. SSME operation timing data.



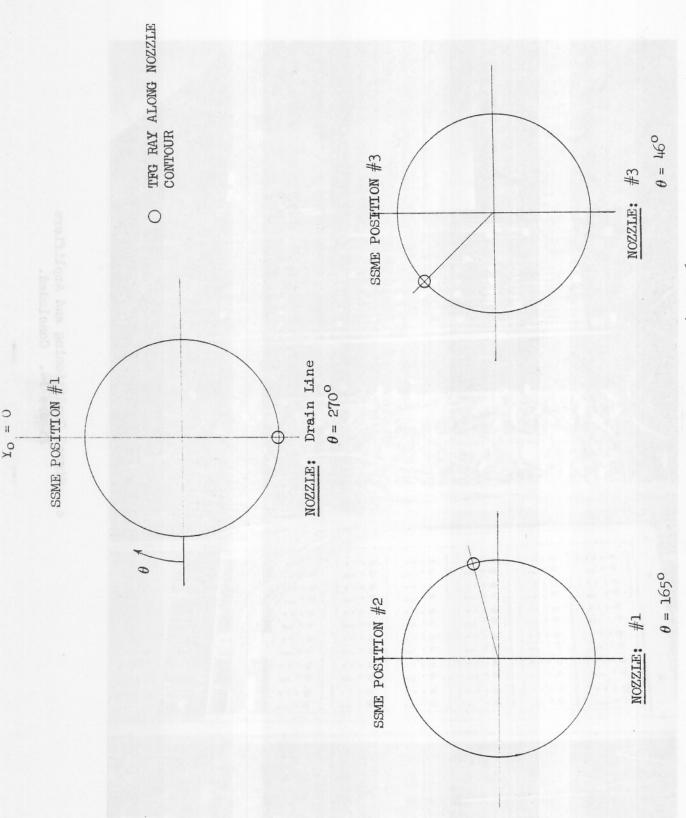
a. FACT Eigure 14. Data acquisition equipment.



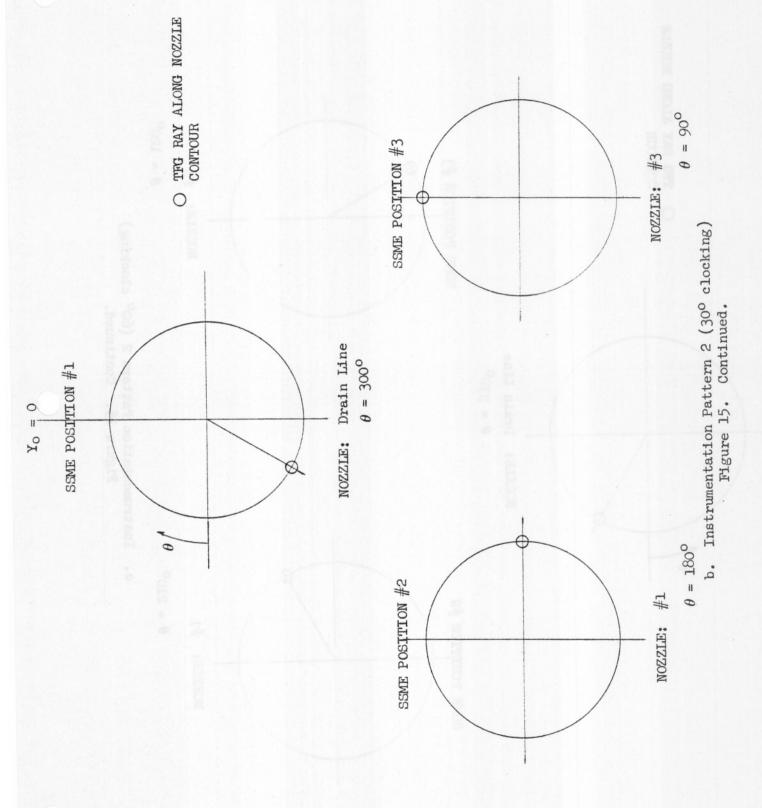
b. Vidar Figure 14. Continued.

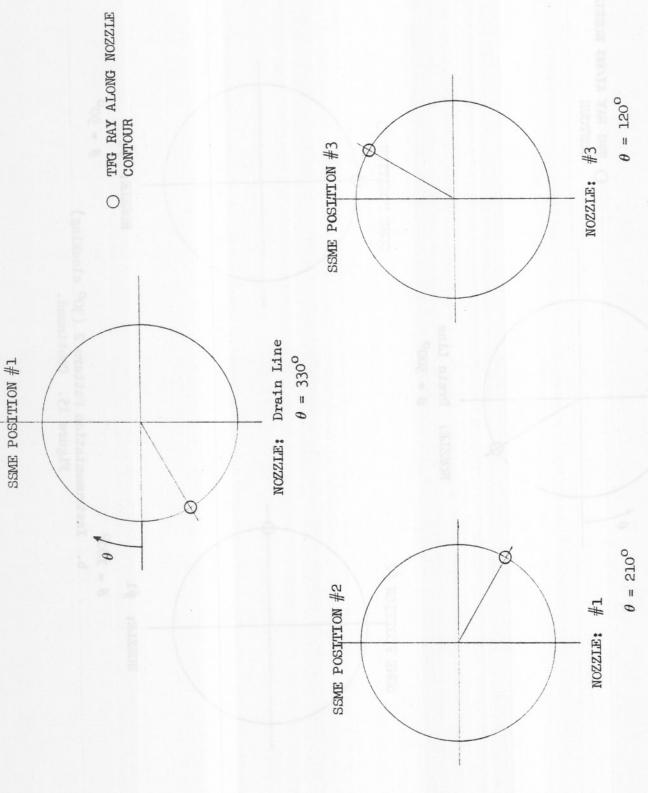


c. Signal Conditioning and Amplifiers Figure 14. Concluded.

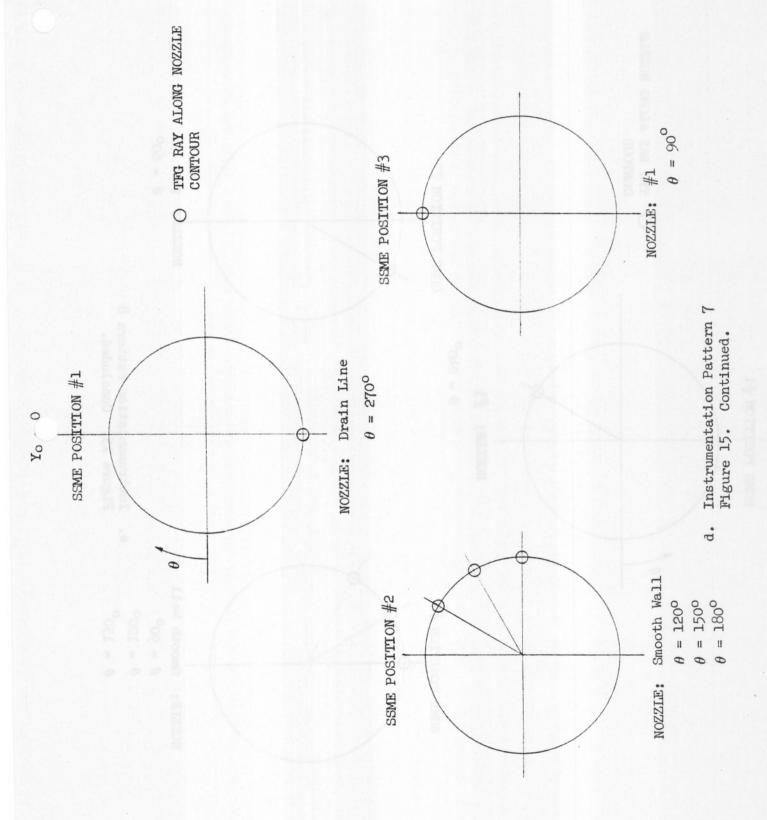


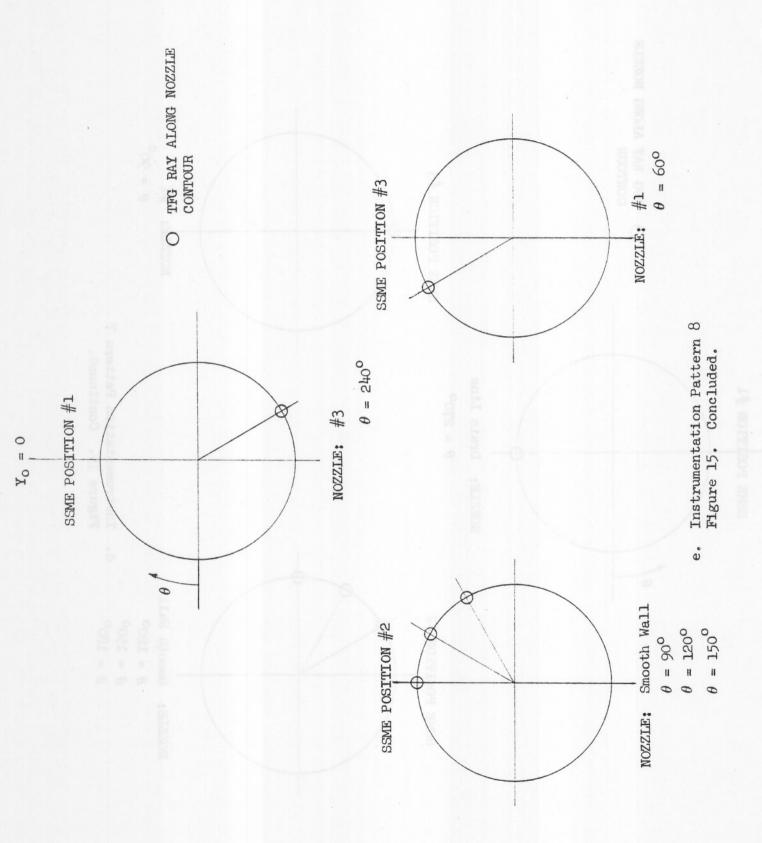
a. Instrumentation Patterns 1, 4 and 6 Figure 15. SSME nozzle orientation.

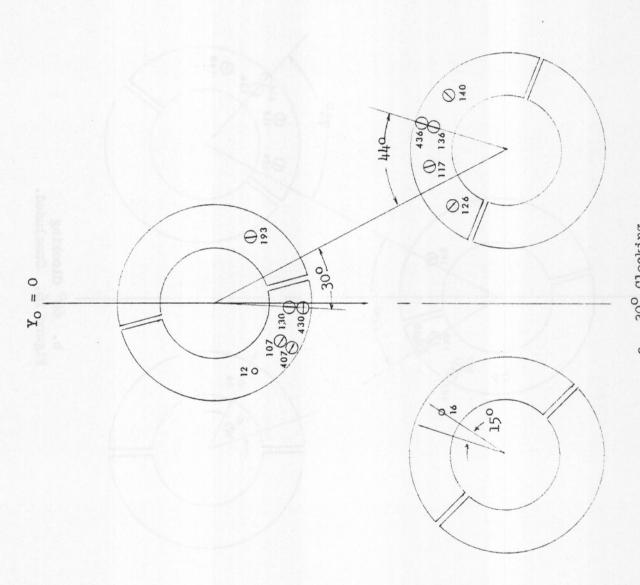




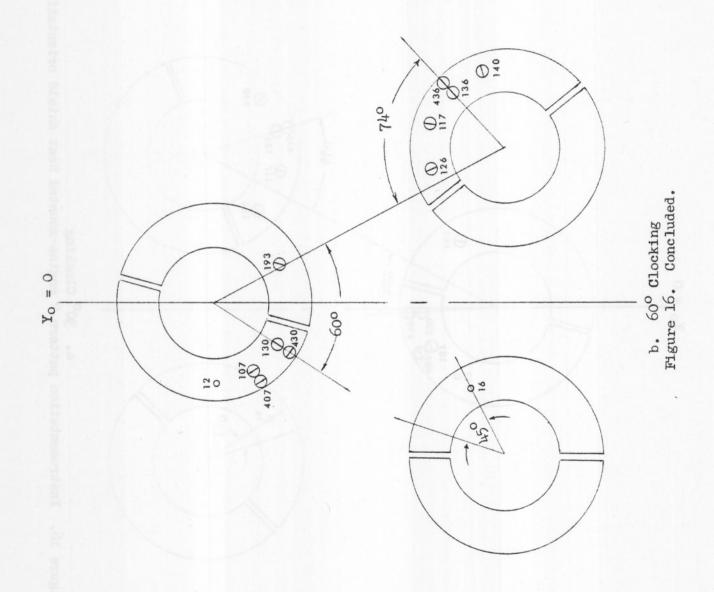
c. Instrumentation Pattern 2 (60° clocking) Figure 15. Continued.







a.  $30^{\rm O}$  Clocking Figure 16. Instrumentation pattern 2 engine-mounted heat shield orientation.



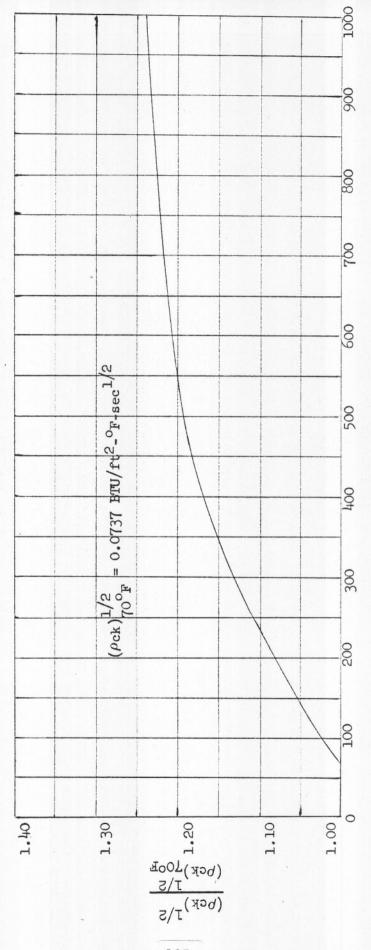


Figure 17. Variation of thin-film gauge substrate (#7740 Pyrex) properties with temperature.

AMBIENT TEMPERATURE, OF

APPENDIX A

SOURCE DATA REFERENCES

#### SOURCE DATA REFERENCES

DATA	ROCKWELL INTERNATIONAL STS AEROSCIENCES DEPARTMENT		
Tabulated	Wind Tunnel Operations Group (R. S. Crowder, Supervisor)	Aero Heating Group  (M. H. Harthun, Supervisor)	
Plot		Aero Heating Group (M. H. Harthun, Supervisor)	

#### APPENDIX B

TABULATED SUMMARY HEAT TRANSFER
DATA CORRECTION FACTORS

SUMMARY HEAT TRANSFER DATA CORRECTION FACTORS

Corrected  $\overline{q}_{ss}$  = Correction Factor x  $\overline{q}_{ss}$ 

CHAMBER ENTRY	RP USED FOR DATA REDUCTION (EQ. 16)	ACTUAL Rp (1/Rp) (RPc)	correction factor (1/RP)0.8
02-4	0.986	1.014	1.0228
02-5	0.950	1.053	1.0855
02-6	0.973	1.028	1.0448
02-7	0.973	1.028	1.0448
03-1	0.931	1.074	1.1212
03-2	0.942	1.062	1.1003
03-3	0.942	1.062	1.1003
03-4	0.944	1.059	1.0966
04-1	0.990	1.010	1.0162
04-2	0.994	1.006	1.0097
04-3	0.999	1.001	1.0016
05-1	0.954	1.048	1.0783
05-2	0.961	1.041	1.0657
06-1	0.989	1.011	1.0179
06-2	0.994	1.006	1.0097
07-1	0.981	1.019	1.0312
07-2	0.905	1.105	1.1732
07-3	0.923	1.083	1.1368
07-4	0.970	1.031	1.0499
07-5	0.923	1.083	1.1368

#### SUMMARY HEAT TRANSFER DATA CORRECTION FACTORS (Continued)

### Corrected $\overline{q}_{ss}$ = Correction Factor x $\overline{q}_{ss}$

CHAMBER	Rp USED FOR DATA REDUCTION (EQ. 16)	ACTUAL Rp (1/Rp) (RPc)	correction factor (1/R <sub>P</sub> )0.8
08-1	0.956	1.046	1.0747
08-2	0.969	1.032	1.0517
08-3	0.973	1.028	1.0448
08-4	0.977	1.024	1.0379
09-1	0.959	1.043	1.0693
09-2	0.969	1.032	1.0517
09-3	0.986	1.014	1.0228
09-4	0.931	1.074	1.1212
- 10-2	0.990	1.010	1.0162
10-3	0.952	1.050	1.0819
10-4	0.969	1.032	1.0517
10-5	0.977	1.024	1.0379
11-1	1.058	0.945	0.9137
11-2	1.049	0.953	0.9263
11-3	1.055	0.948	0.9179
11-4	1.036	0.965	0.9450
12-1	1.070	0.935	0.8974
12-2	1.040	0.962	0.9392
12-3	1.028	0.973	0.9568
12-4	1.020	0.980	0.9688

#### SUMMARY HEAT TRANSFER DATA CORRECTION FACTORS (Continued)

# Corrected $\overline{q}_{ss}$ = Correction Factor x $\overline{q}_{ss}$

CHAMBER ENTRY	Rp USED FOR DATA REDUCTION (EQ. 16)	ACTUAL Rp (1/Rp) (RPc)	CORRECTION FACTOR
12-5	1.020	0.980	0.9688
13-1	1.0575	0.946	0.9144
13-2	1.029	0.972	0.9553
13-3	1.036	0.965	0.9450
14-1	1.045	0.957	0.9320
14-2	1.032	0.969	0.9509
14-3	1.045	0.957	0.9320
15-1	1.041	0.961	0.9377
15-2	1.041	0.961	0.9377
15-3	1.015	0.985	0.9765
15-4	0.998	1.002	1.0032
15-5	1.015	0.985	0.9765
15-5	1.011	0,989	0.9826
15-7	0.973	1.028	1.0448
16-2	1.007	0.993	0.9889
16-3	0.9901	1.010	1.0160
16-4	0.9817	1.019	1.0300
16-5	0.986	1.014	1.0228
17-2	1.0323	0.969	0.9504
17-3	1.049	0.953	0.9263

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CHAMBER ENTRY	RP USED FOR DATA REDUCTION (EQ. 16)	ACTUAL Rp (1/Rp) (Rpc)	CORRECTION FACTOR (1/R <sub>P</sub> ) <sup>0.8</sup>
17-4	1.011	0.989	0.9826
19-1	0.9859	1.014	1.0230
19-2	1.01133	0.989	0.9821
20-1	1.0154	0.985	0.9758
20-2	0.9969	1.003	1.0050
20-3	0.9986	1.001	1.0022
20-4	0.9817	1.019	1.0300
21-1	0.982	1.018	1.0295
21-2	0.9775	1.023	1.0371
21-3	0.969	1.032	1.0517
22-1	0.96485	1.036	1.0589
22-2	0.9775	1.023	1.0371
22-3	0.9738	1.027	1.0434
22-4	0.96485	1.036	1.0589
23-2	1.02384	0.977	0.9630
23-3	1.02805	0.973	0.9567
23-4	0.9943	1.006	1.0092
23-5	1.0028	0.997	0.9955
24-1	0.9943	1.006	1.0092
24-2	0.965	1.036	1.0587

### SUMMARY HEAT TRANSFER DATA CORRECTION FACTORS (Continued)

## Corrected $\overline{q}_{ss}$ = Correction Factor x $\overline{q}_{ss}$

CHAMBER ENTRY	RP USED FOR DATA REDUCTION (EQ. 16)	ACTUAL Rp (1/Rp) (Rpc)	CORRECTION FACTOR (1/R <sub>P</sub> )0.8
24-3	0.948	1.055	1.0892
25-1	0.948	1.055	1.0892
25-2	0.9354	1.069	1.1128
25-3	0.9227	1.084	1.1374
25-4	0.9227	1.084	1.1374
26-2	1.0154	0.985	0.9758
26-3	0.961	1.041	1.0657
26-4	1.0007	0.999	0.9989
26-5	0.944	1.059	1.0966
27-1	0.851	1.175	1.2945
27-2	0.872	1.147	1.2450
27-3	0.792	1.263	1.4522
27-4	0.864	1.157	1.2635
28-1	0.943	1.060	1.0985
28-2	0.943	1.060	1.0985
29-1	0.906	1.104	1.1711
29-2	0.902	1.109	1.1794
29-3	0.890	1.124	1.2050
29-4	0.910	1.099	1.1629
30-1	0.973	. 1.028	1.0448

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CHAMBER ENTRY	RP USED FOR DATA REDUCTION (EQ. 16)	ACTUAL Rp (1/Rp) (Rpc)	correction factor (1/RP)0.8
30-2	1.072	0.933	0.8947
30-3	1.079	0.927	0.8855
30-4	1.063	0.941	0.9069
31-1	1.070	0.935	0.8974
31-2	1.078	0.928	0.8868
	889.0	1.02.5	
	1.040.1	0.961	
	999.0	1.0007	4-35
	1.059	#49.0	e-8s
	1.175	0.851	1-75
	1.10	\$73.0	9-79
	1.263	507.0	8-13
	1.157	438.0	4-73
	1.060	£49.0	1-83
	1.060	848.0	28-2
	1.100	90510	1-68
	1.109	0.903	S-9S
	1.124	008.0	8-62
	1.099	0.910	4-68
	1.028	0.973	30-1